

Atomistic understanding of transport through a single dopant atom in a MOSFET

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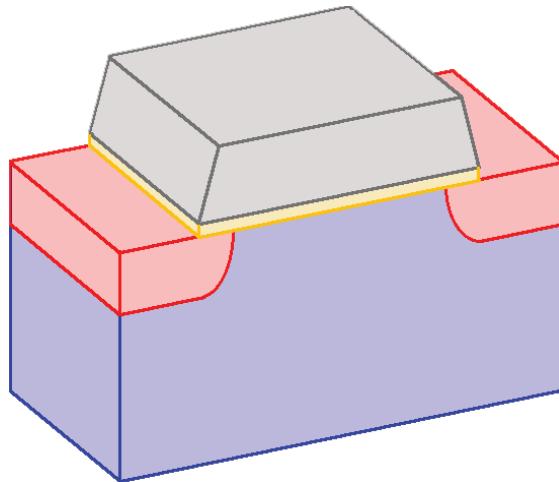
www.ns.tudelft.nl/pd

EU/FET Cluster meeting
November 14th 2007

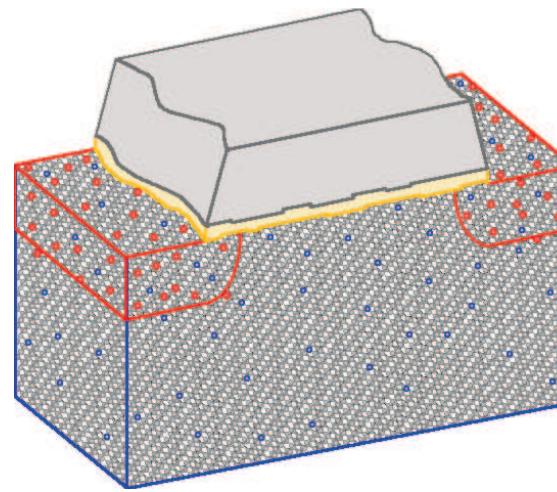


Delft University of Technology

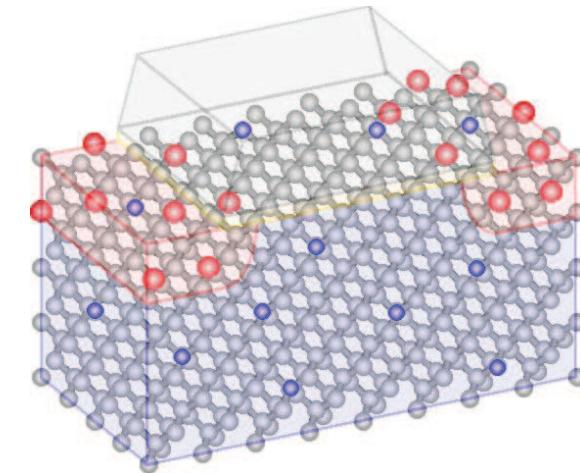
Atomic-scale electronics



“bulk” transistor (FET)



32 nm MOSFET

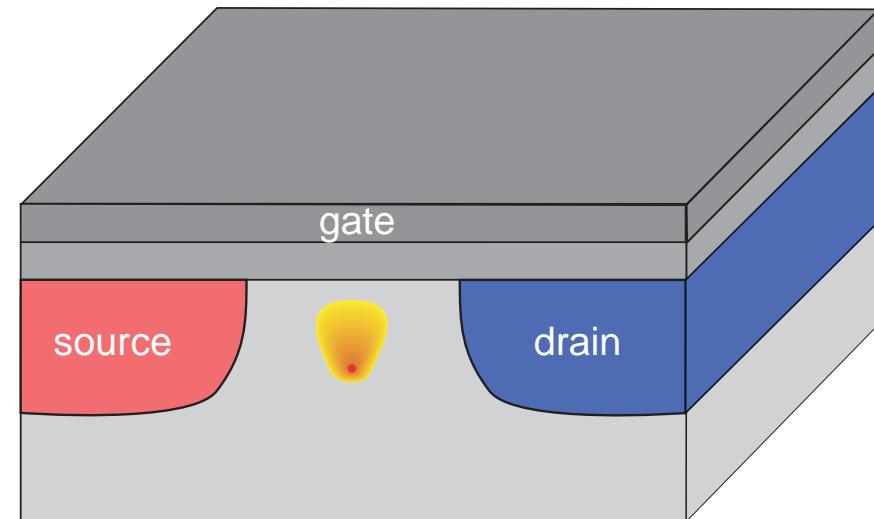
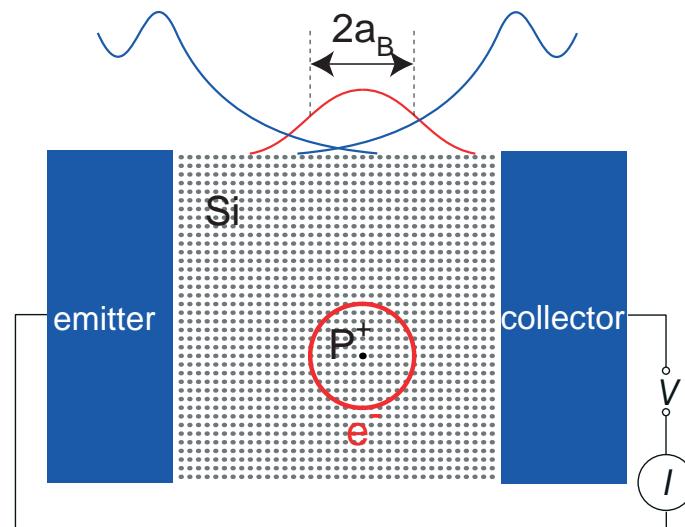


4 nm MOSFET ???

[Asenov IEEE Trans. Elec. Dev. 50, 1837, 2003]

bulk → atomistic: a *problem* for industry, an *opportunity* for science

Opportunity: Use atomic nature of a dopant for new functionality



Scaling of the Bohr orbit:

$$r_{\text{dopant}} = \frac{\epsilon_r}{m^*} \cdot r_{\text{Hydrogen}}$$

$$r_{\text{Hydrogen}} = 0.05 \text{ nm}$$

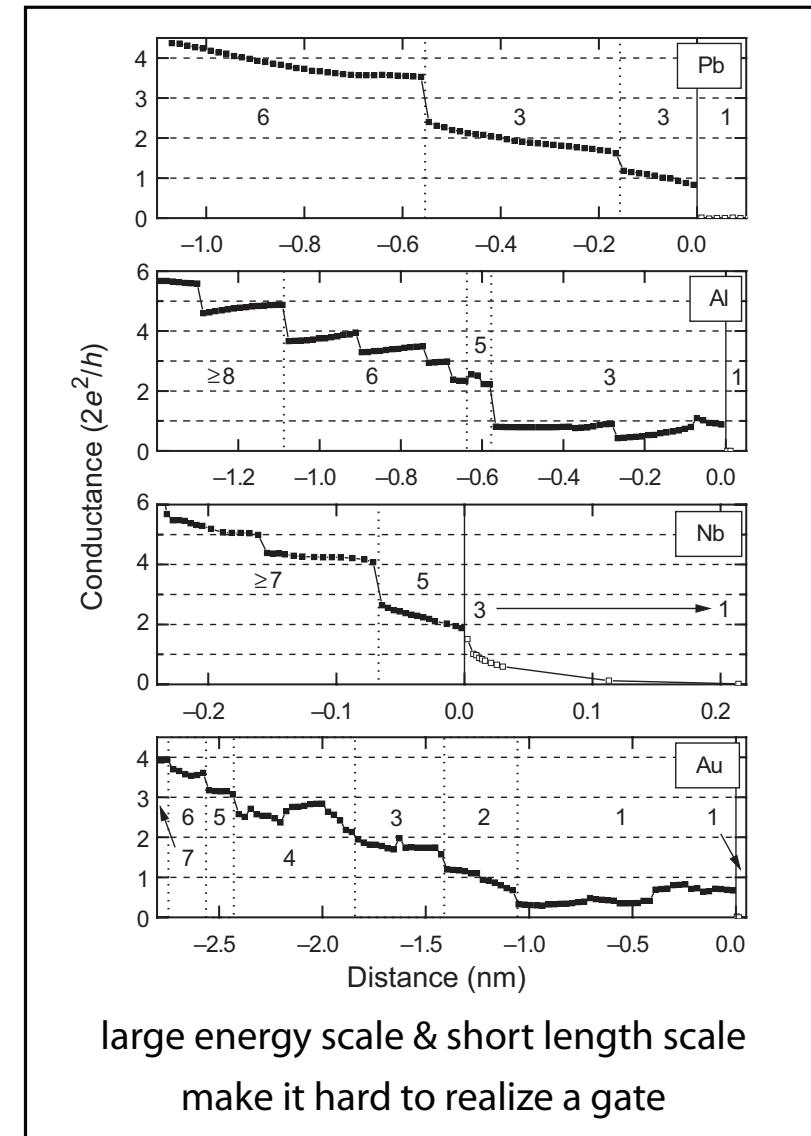
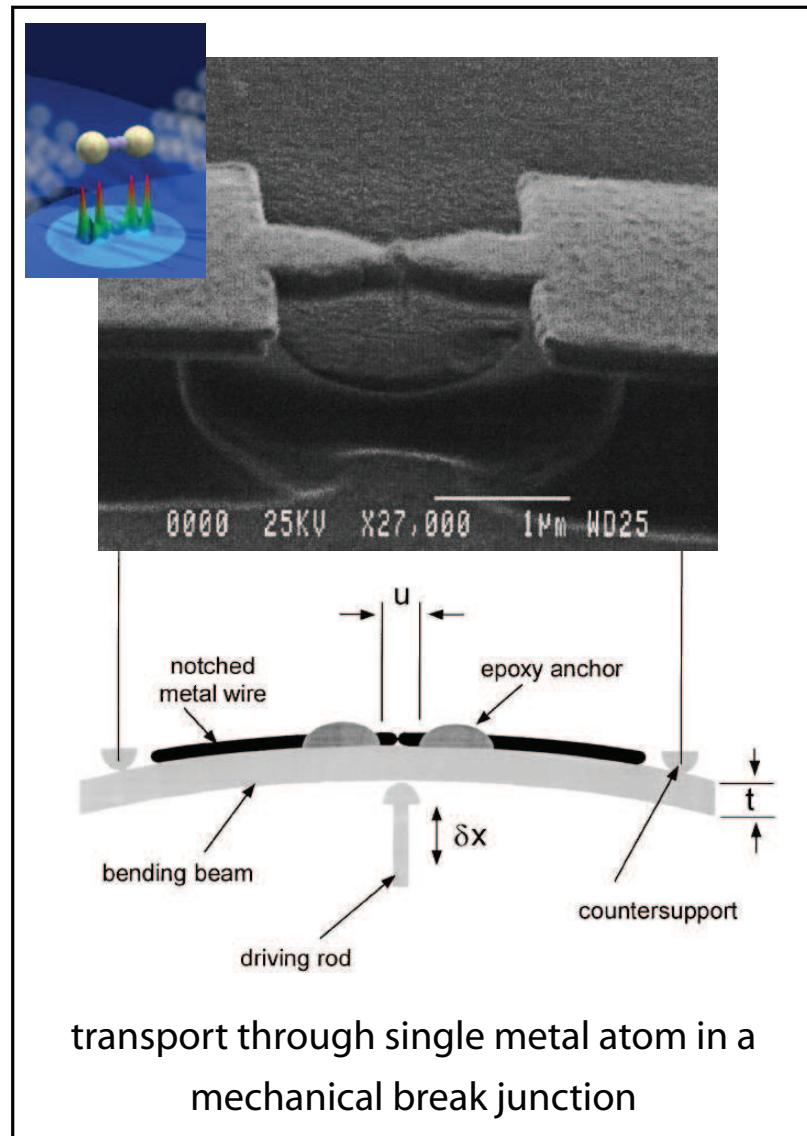
$$r_{\text{P:Si}} = 2.5 \text{ nm}$$

$$r_{\text{P:Ge}} = 6.4 \text{ nm}$$

Physics of a single atom in a solid state matrix

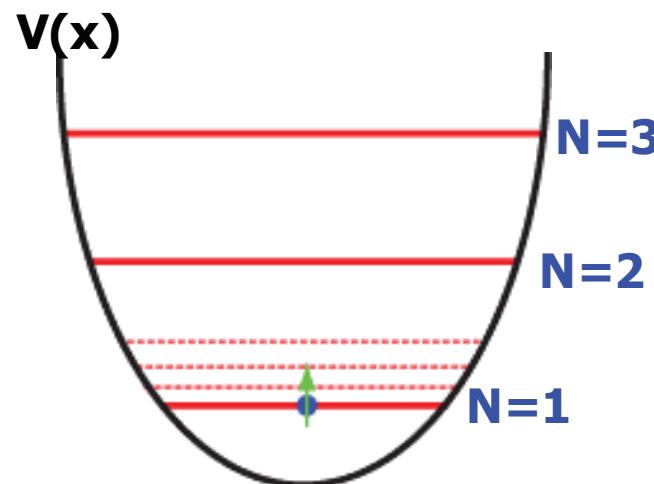
- smallest length scale of a semiconductor device
- FET based on atomic orbitals
- 300 K quantum devices (deeper impurities)?

Analogy to our work: Atomic-scale electronics in a metal



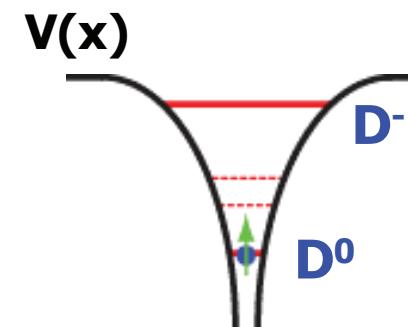
Atomic systems in a semiconductor

Quantum dots

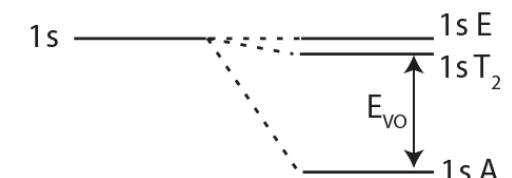
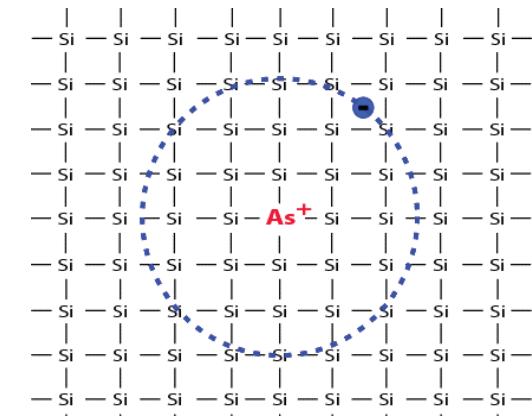


- Parabolic potential
- Constant charging energy
- Equidistant level spacing (excited states)

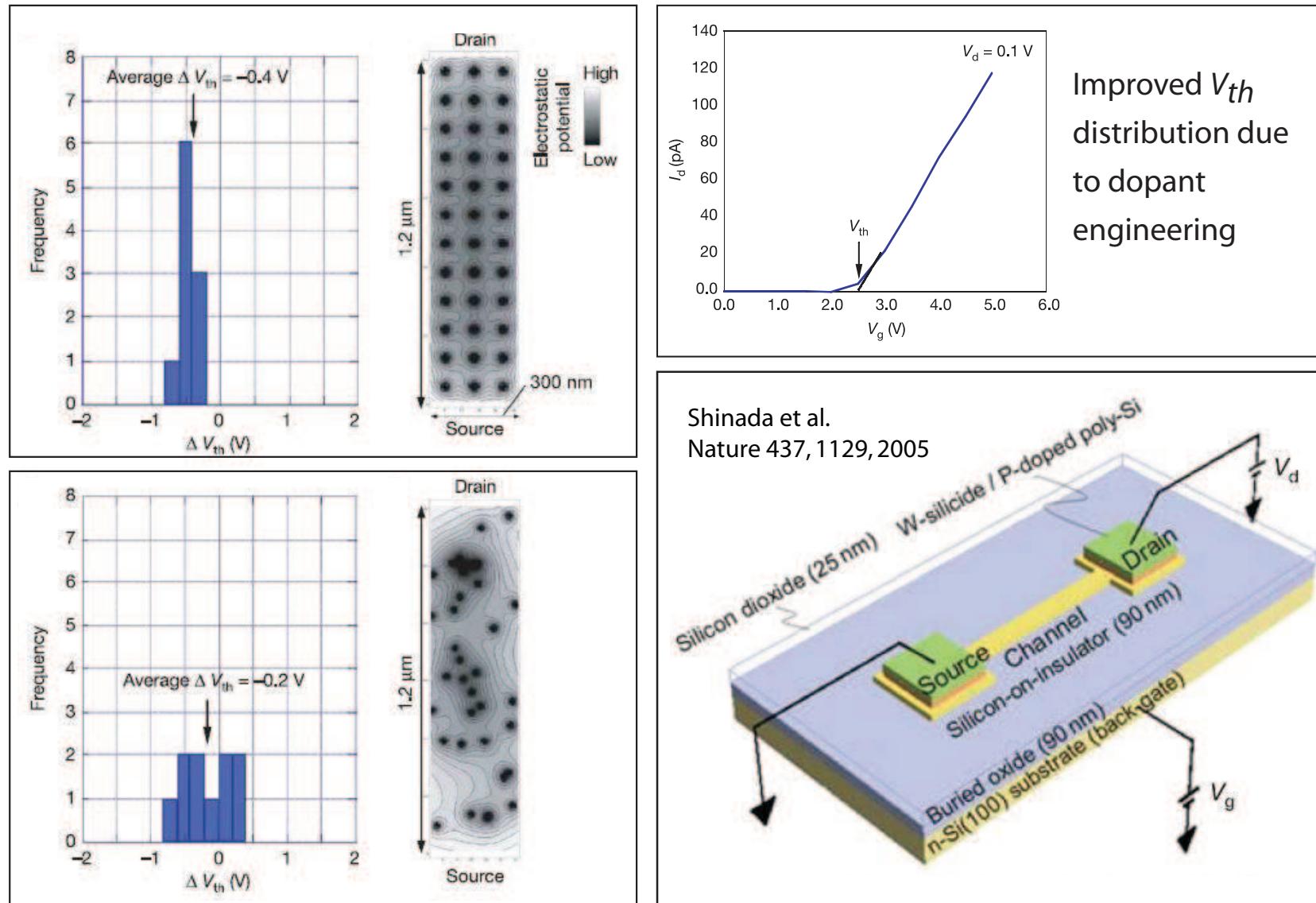
Dopant: shallow donors in Si



- Coulomb potential
- Can bind up to two electrons
- Hydrogen-like level spectrum (D^0)
- Valley-orbit →

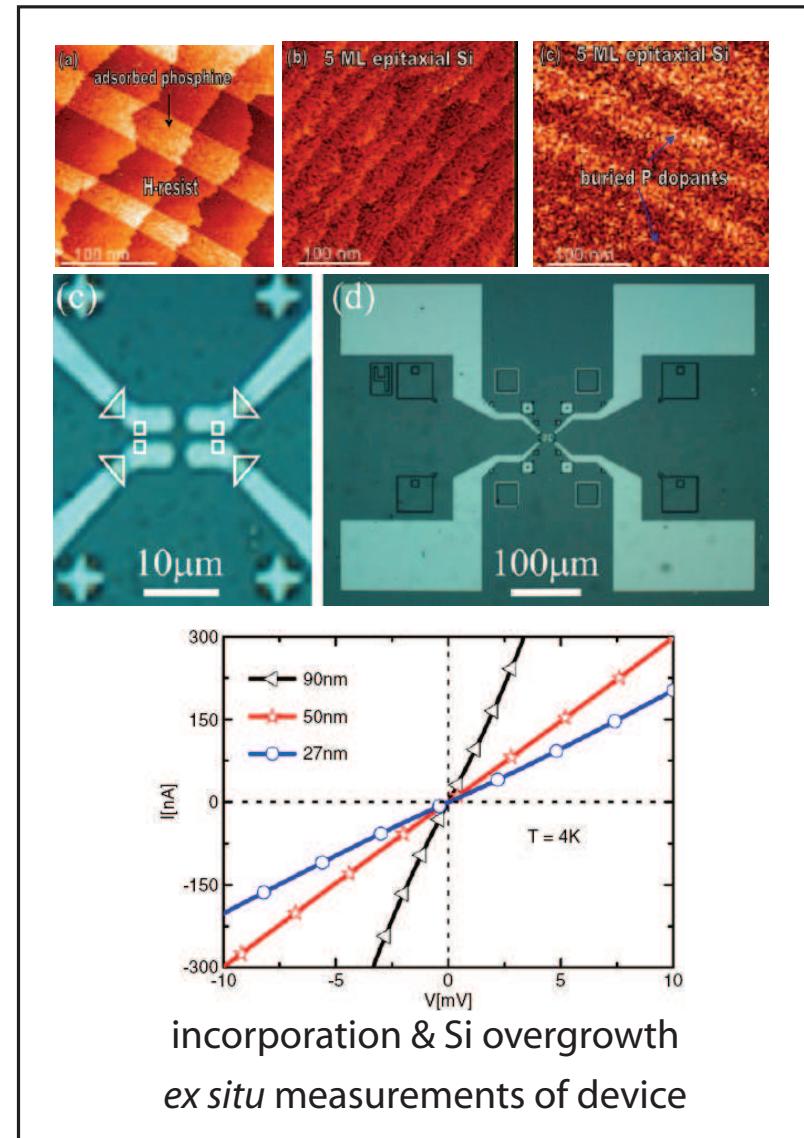
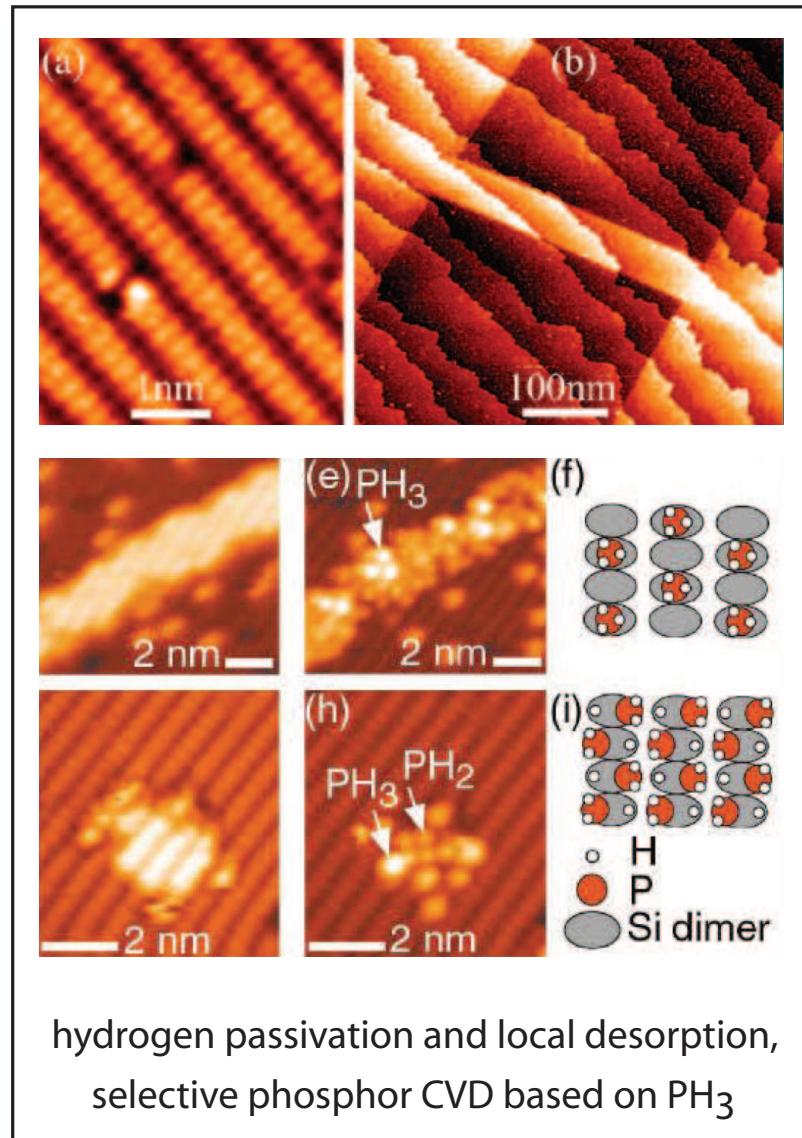


Recent progress in top-down dopant engineering

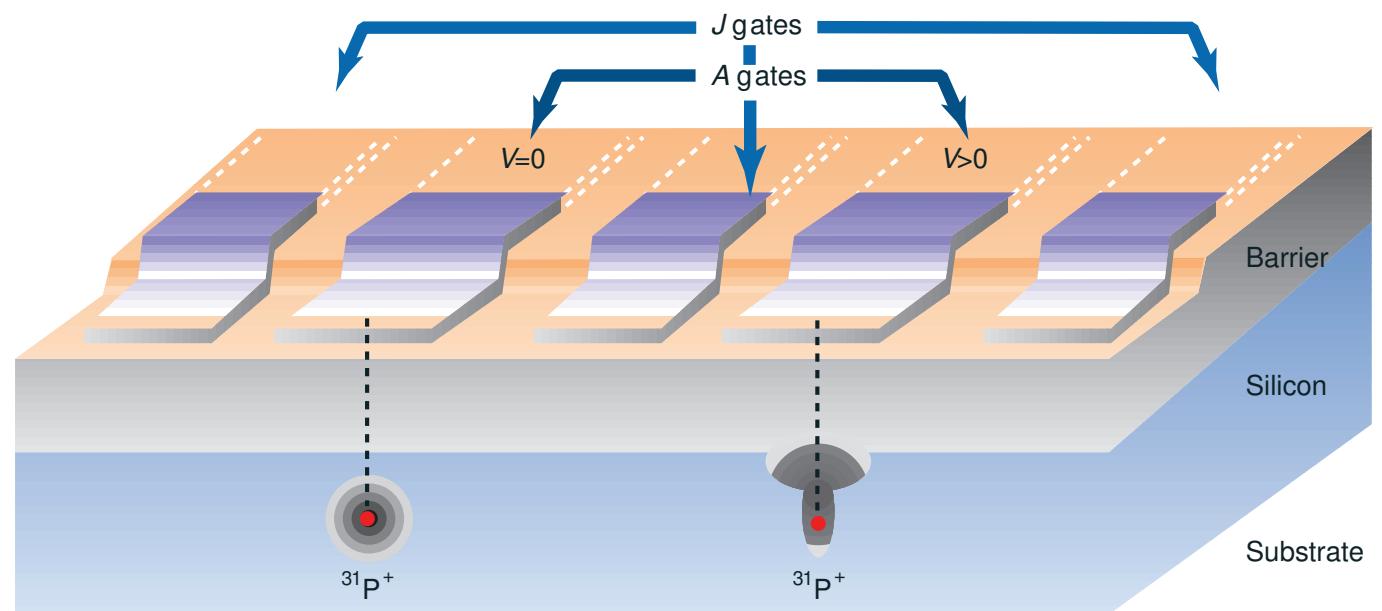
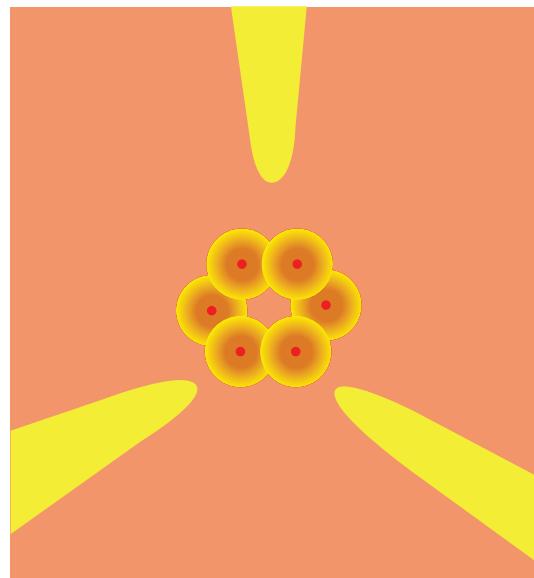


Ultimate goal: Dopant superlattice [Esaki & Tsu, IBM J. Res. Dev. '70]

Recent progress in bottom-up dopant engineering



New device concepts based on atomic functionality



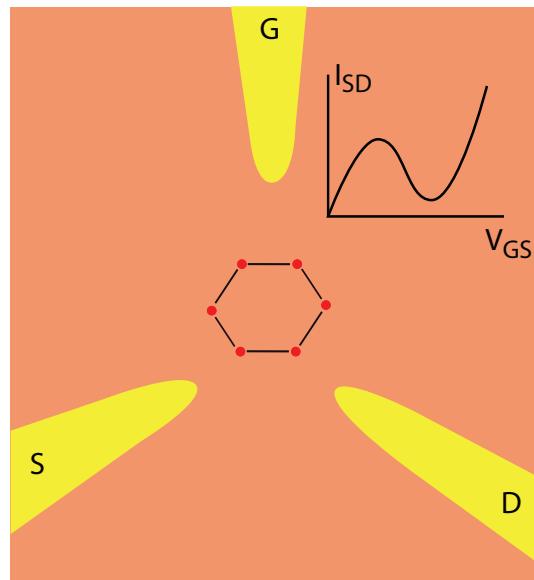
[molecular electronics in the solid state]

[Kane Nature 393, 133, 1998]

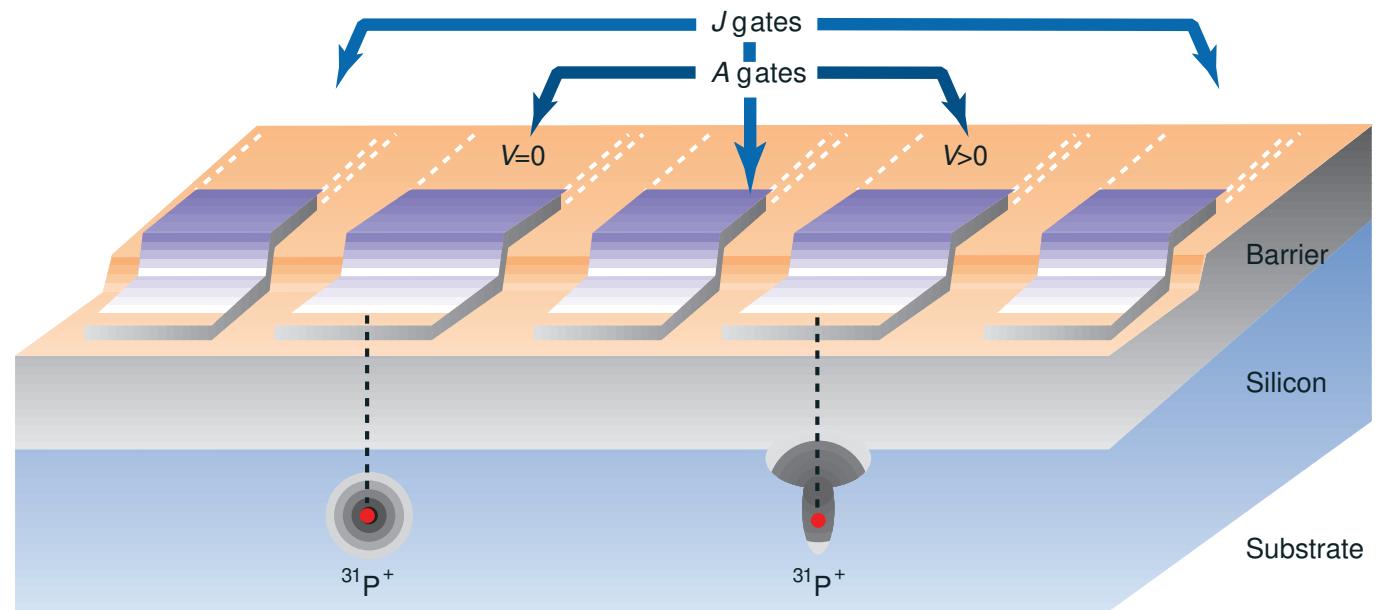
Devices utilizing the atomic nature of a dopant atom:

- solid-state molecules based on bound states of electrons or holes in a semiconductor
- important length scale = Bohr orbit → addressable via gate control
- quantum coherent devices: Si/Ge attractive due to long spin coherence times

New device concepts based on atomic functionality



[molecular electronics in the solid state]

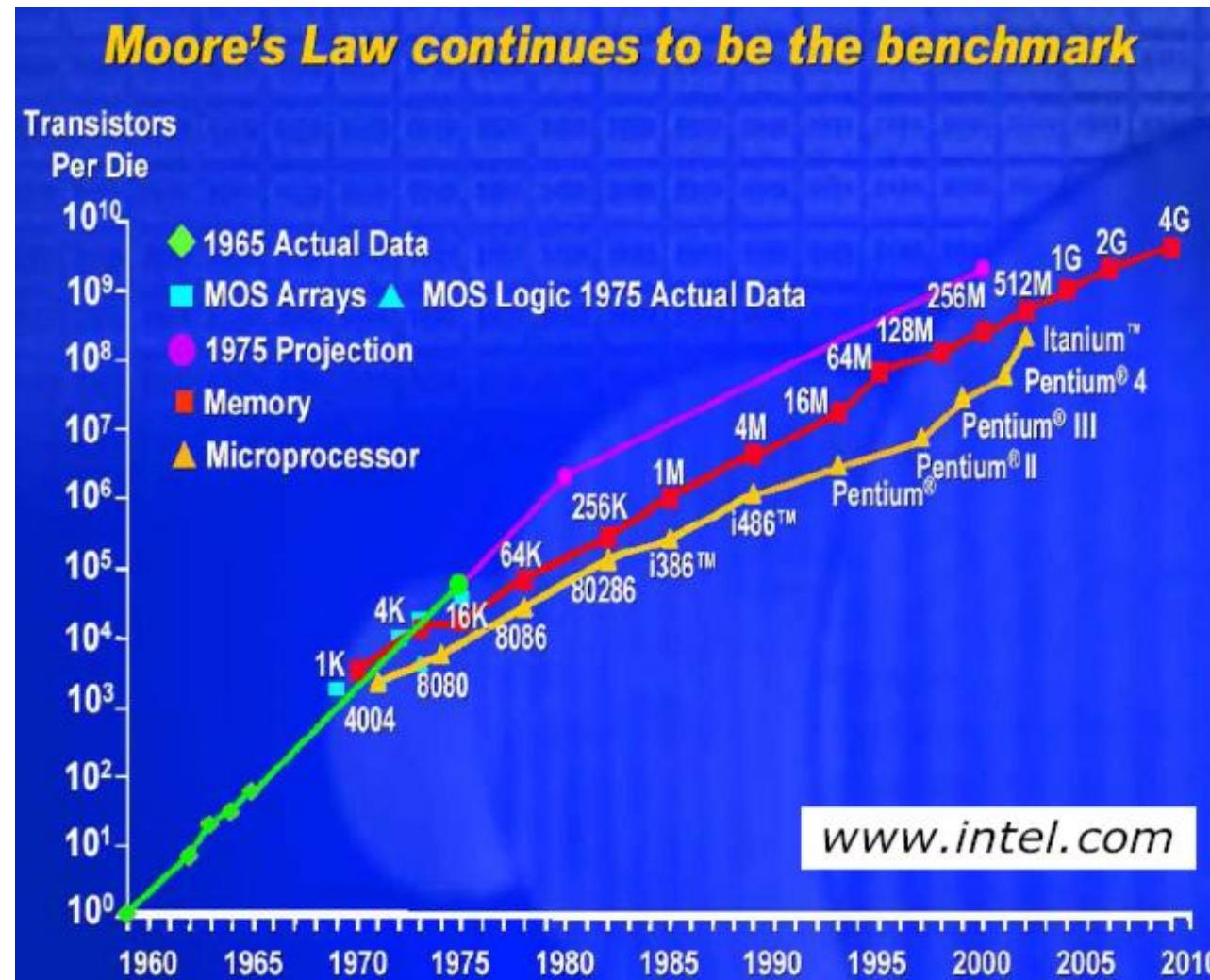


[Kane Nature 393, 133, 1998]

Devices utilizing the atomic nature of a dopant atom:

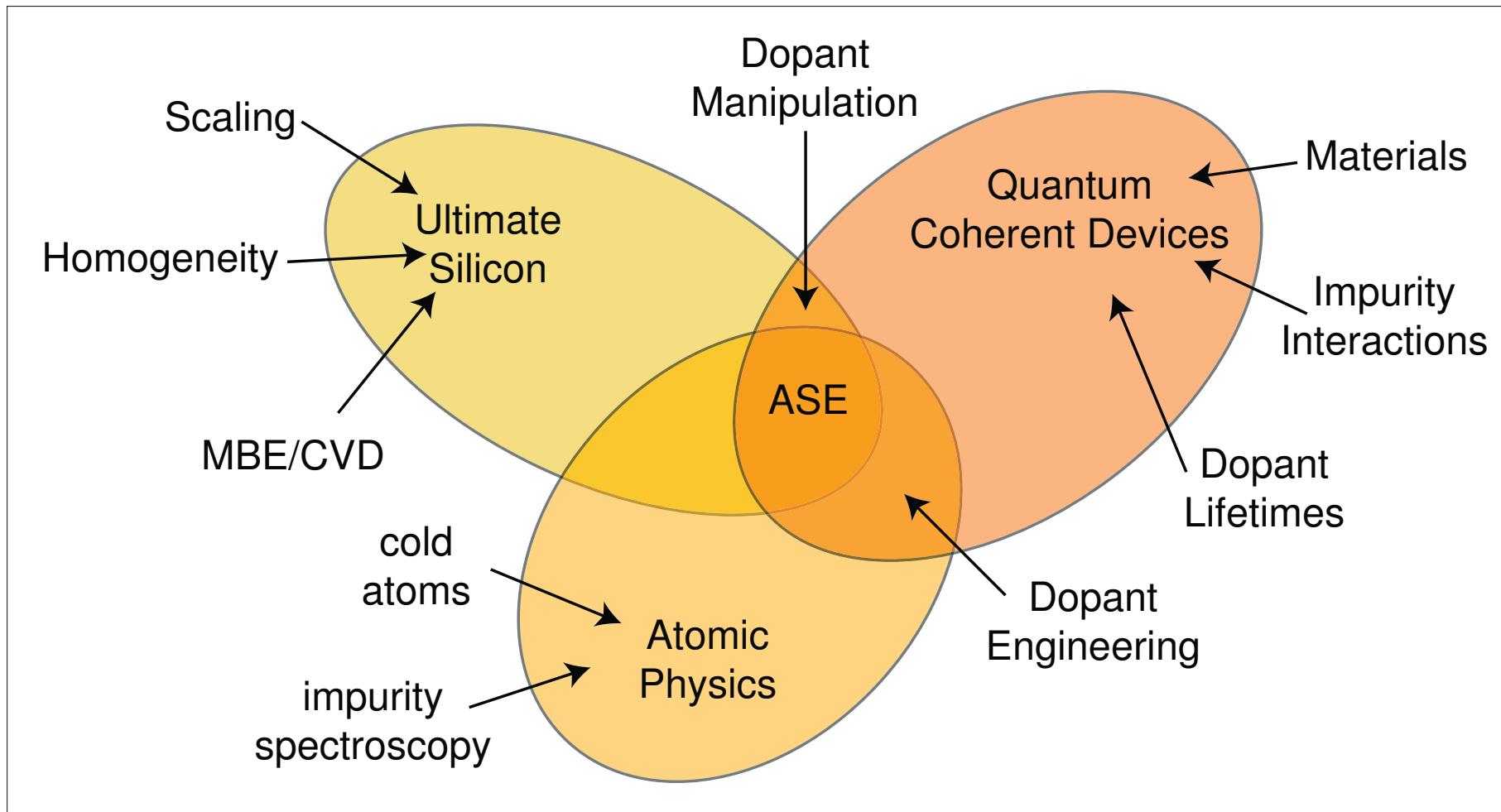
- solid-state molecules based on bound states of electrons or holes in a semiconductor
- important length scale = Bohr orbit → addressable via gate control
- quantum coherent devices: Si/Ge attractive due to long spin coherence times

New functionality in CMOS at the end of the roadmap

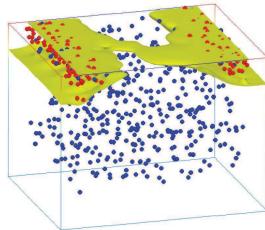


use ultimate CMOS technology to achieve new functionality in this material system

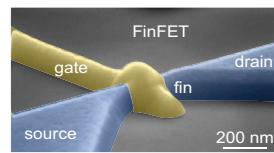
Atomic-scale electronics



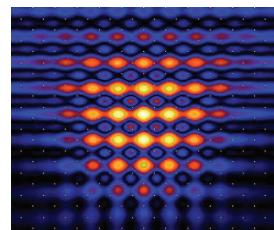
Outline



- Atomic-scale electronics



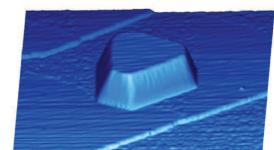
- Access to a single dopant in a nano-MOSFET



- Atomic physics in a MOSFET

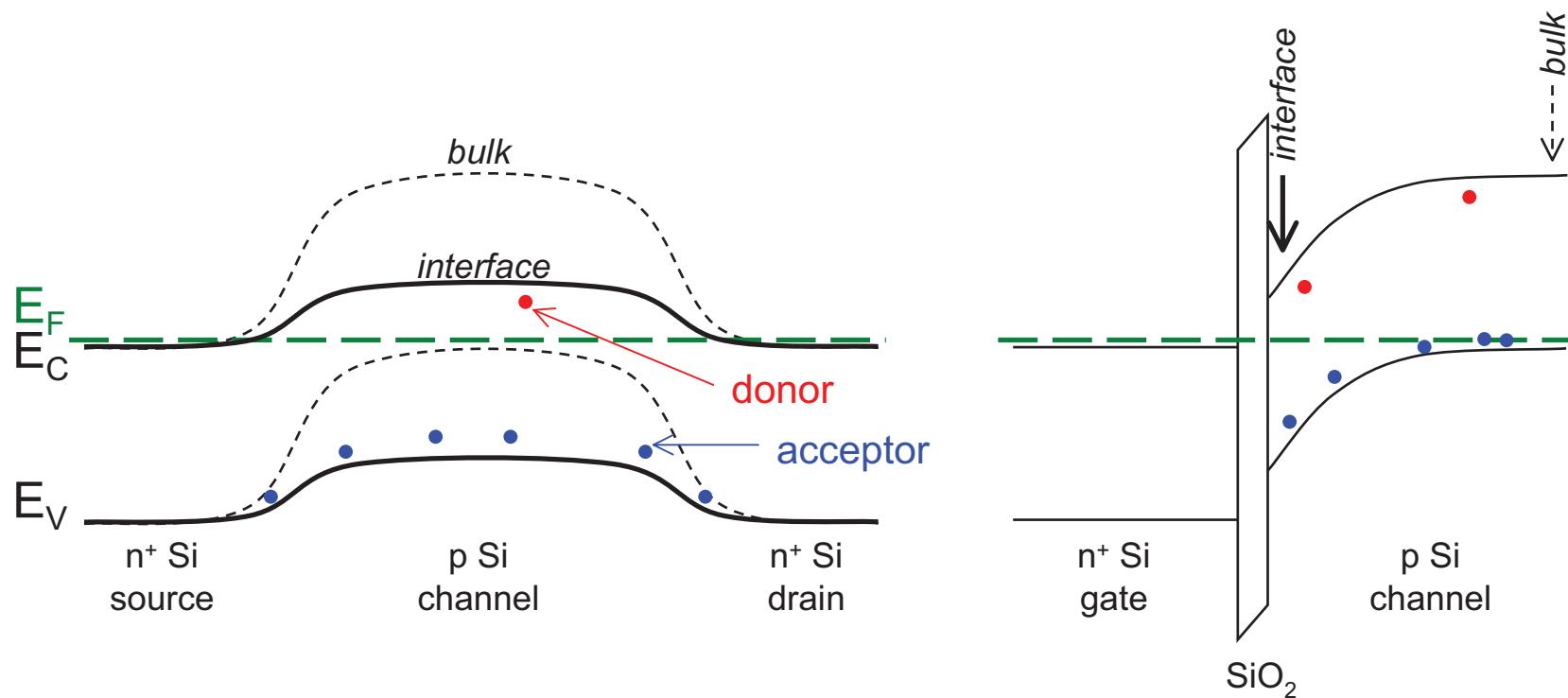
Σ

- Summary



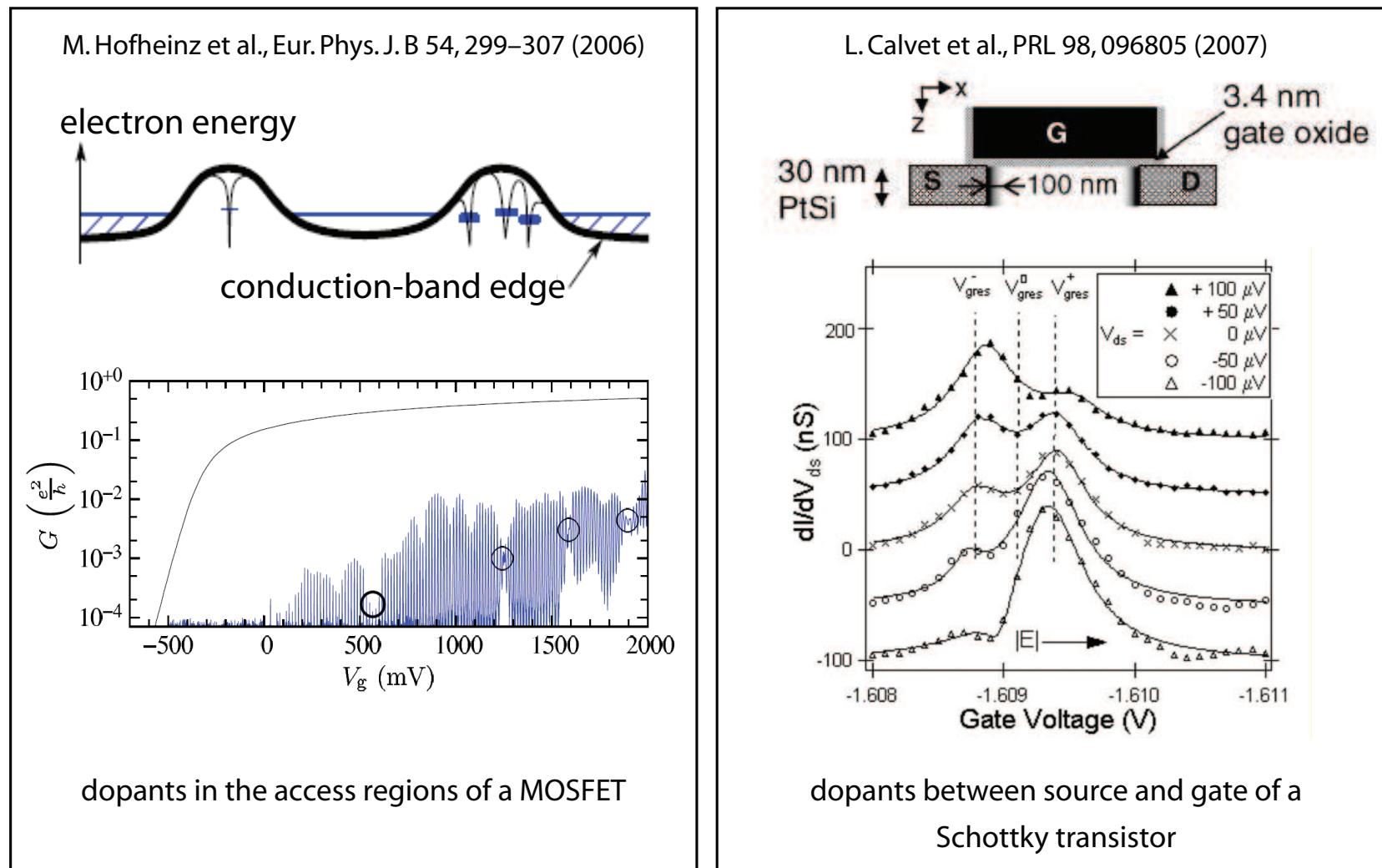
- Other projects

How many dopants are in a FET?



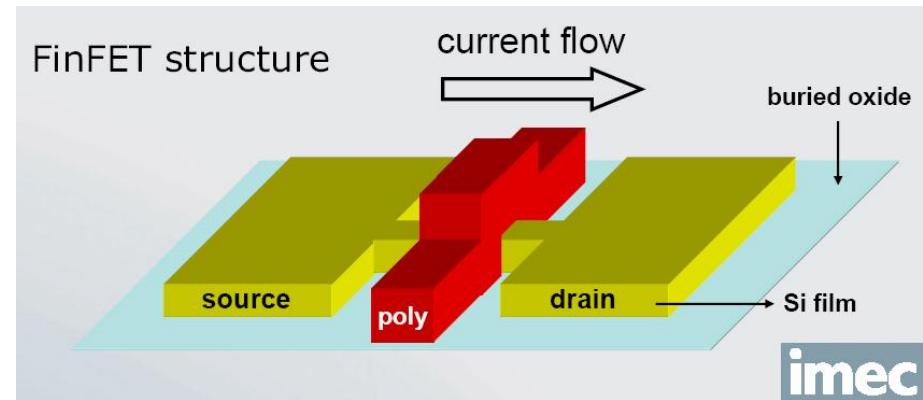
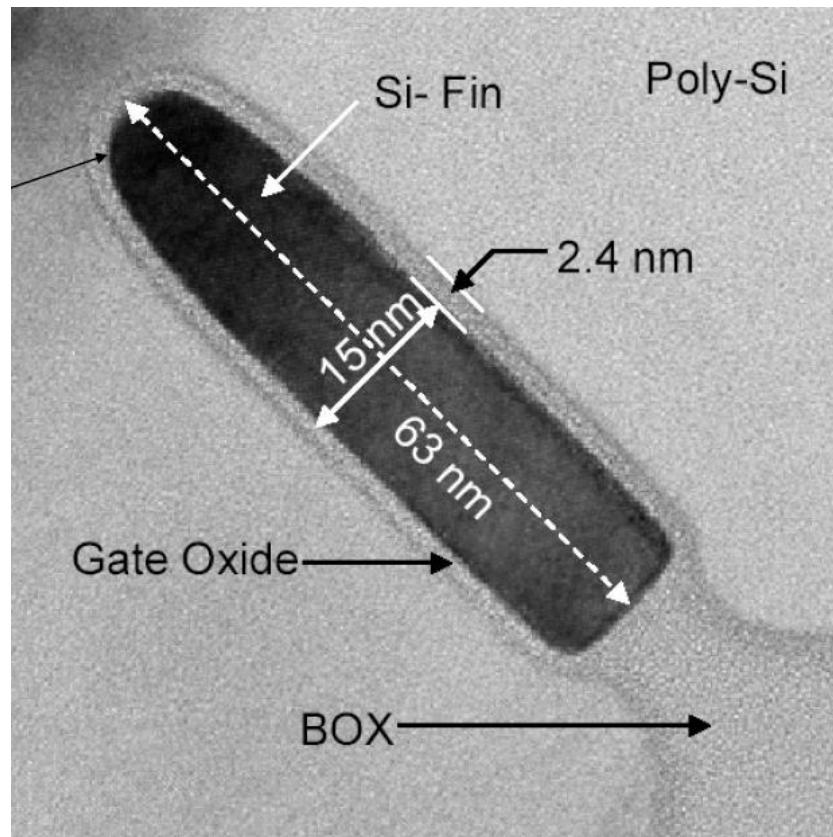
- How many dopants are there?
 - $N(\text{acceptors}) = 10^{18}/\text{cm}^3 \times (60 \times 60 \times 35\text{nm}^3) \approx 125$
 - $N(\text{acceptors in resonance}) = (60 + 60 + 35\text{nm})/(10^{18}/\text{cm}^3)^{1/3} \approx 15$
 - $N(\text{donors}) = \text{less than acceptors} \rightarrow \text{may be observed individually}$
- Which dopants are probed?
 - **acceptors:** require interband tunneling → no
 - **donors:** subthreshold current at interface → yes

Transport through dopants in a MOSFET



strong recent interest in transport through dopants but not with dopants in the channel

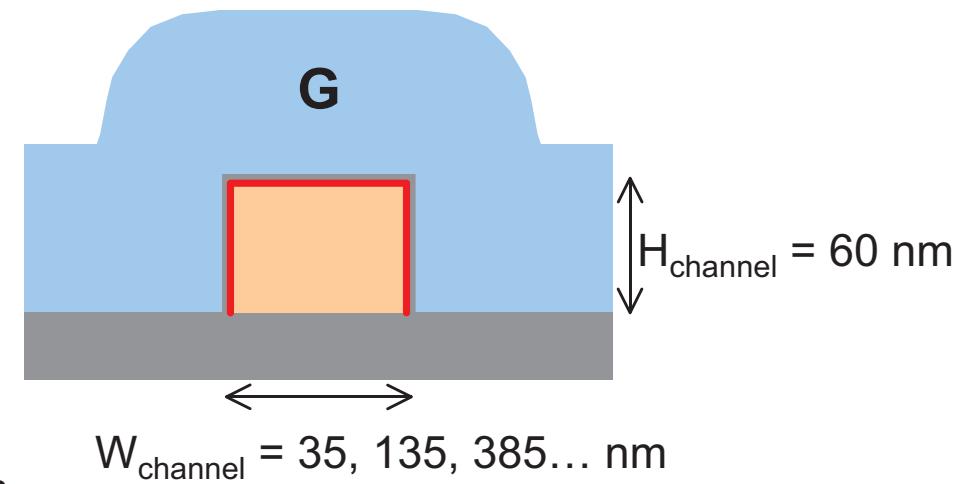
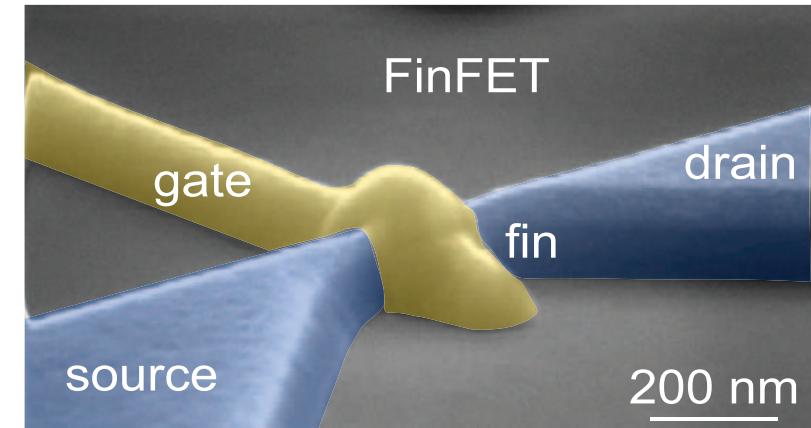
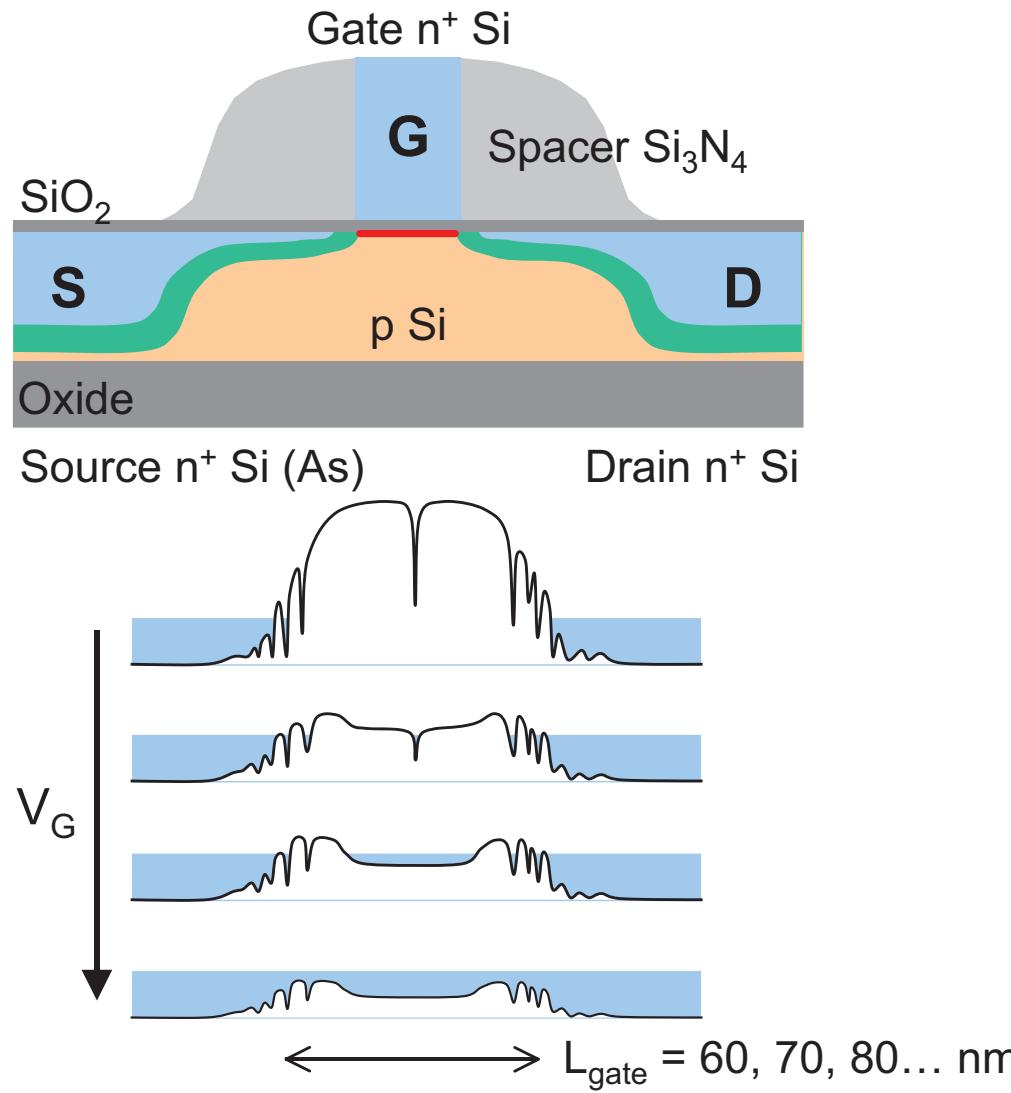
Multi-gate FET (FinFET) from S. Biesemans group (IMEC)



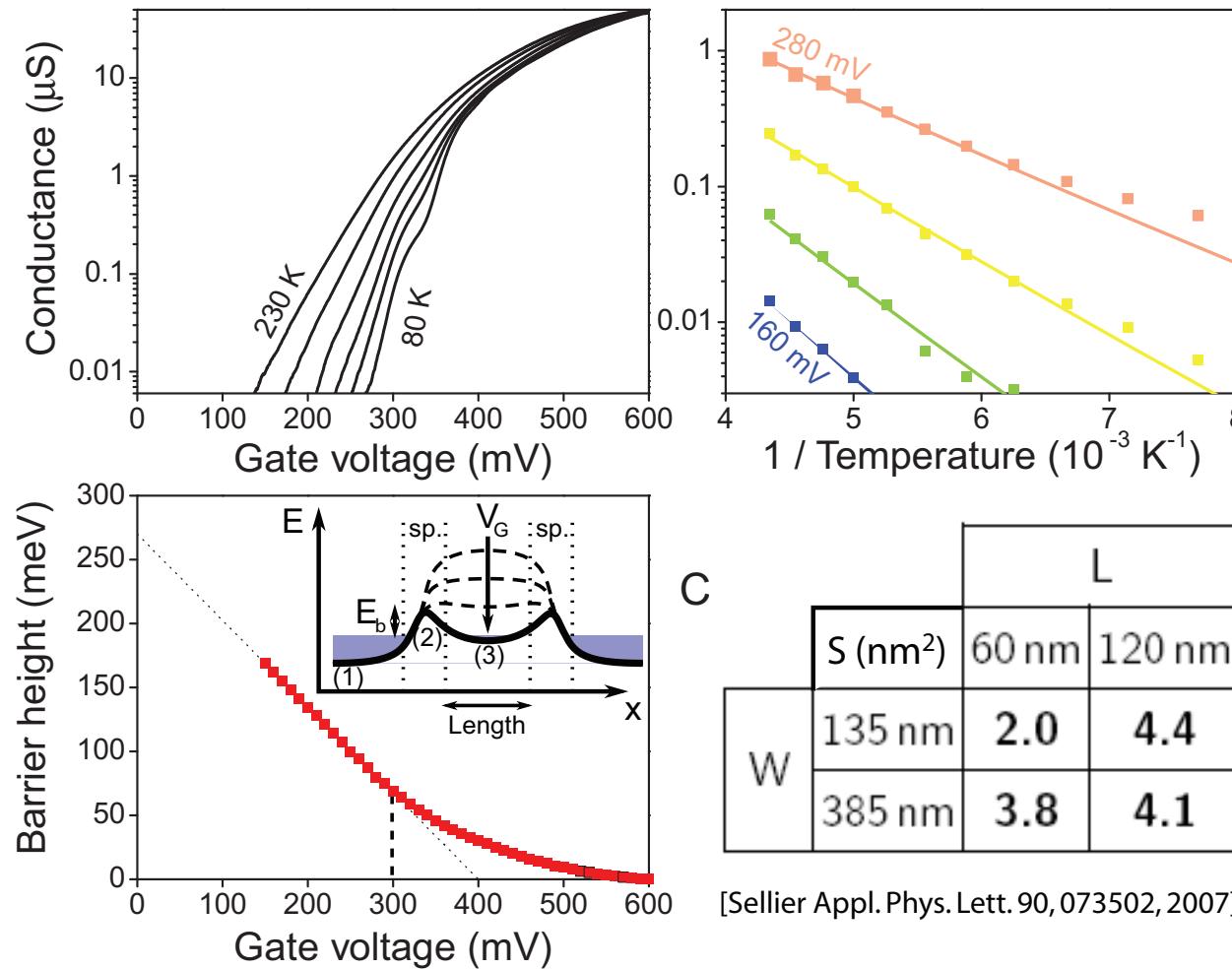
[Nadine Collaert, IMEC]

- application: lithographically defined Si nanowires (fins) covered by a single gate
- our experiments: single fin devices, here fin width 15 nm & gate length 20 nm

Transport through a FinFET

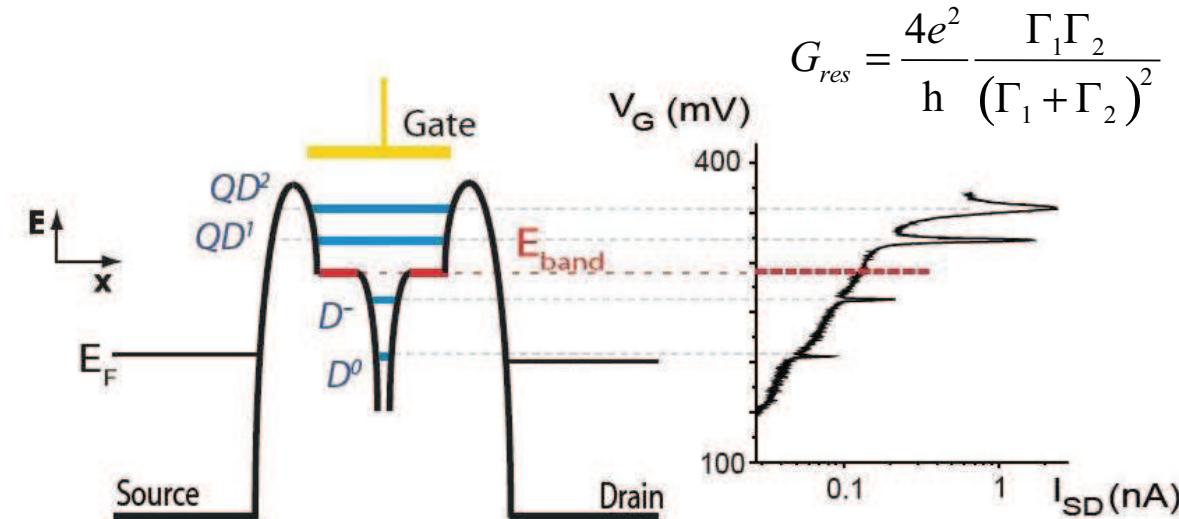
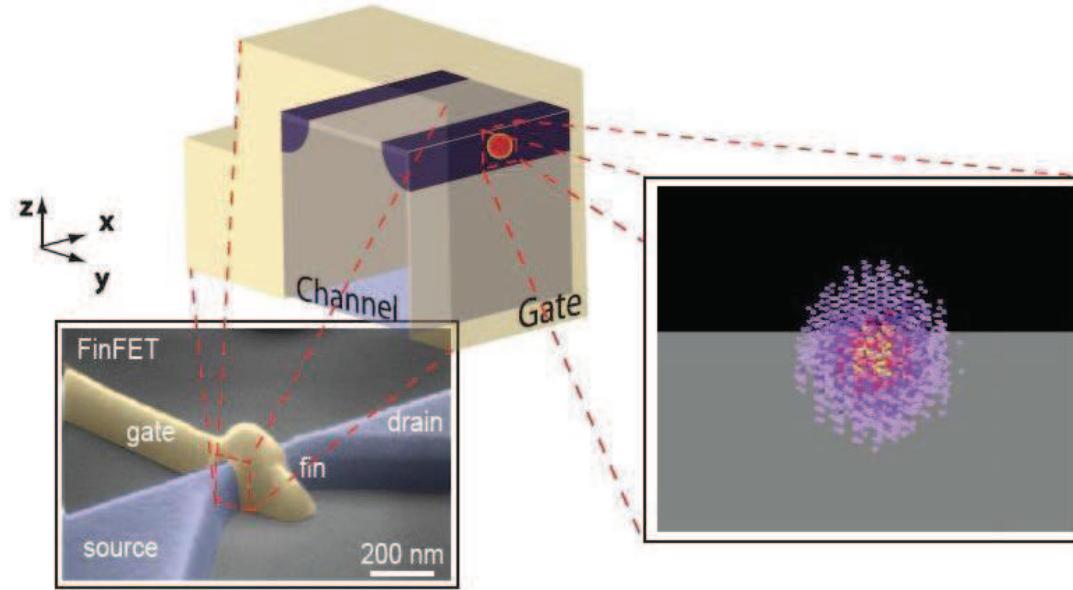


Thermionic emission in a FinFET: corner effect



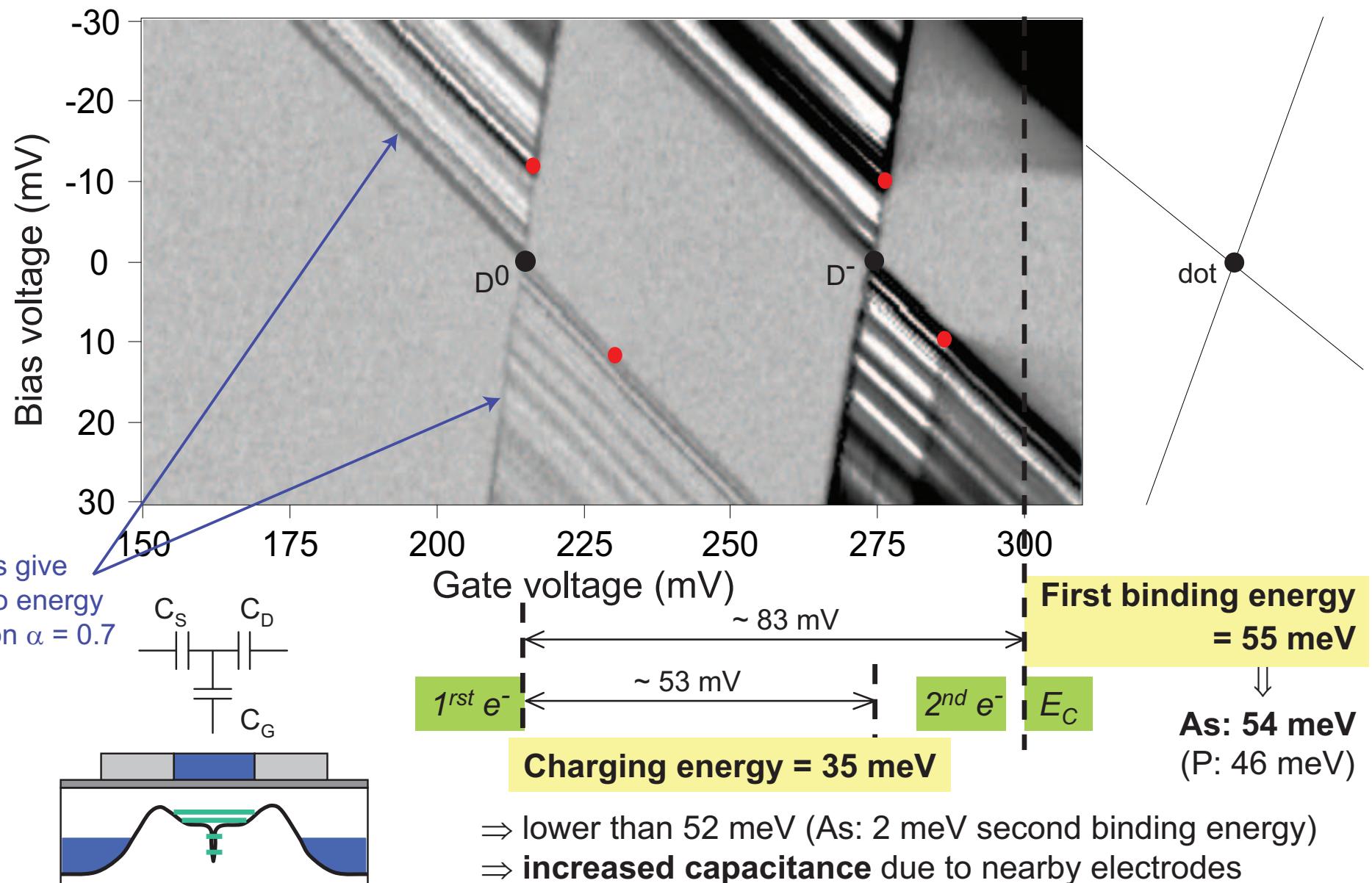
- $G = S A^* \frac{e}{k_B T} T \exp\left(-\frac{E_b}{k_B T}\right)$ [A^* for Si is $2.1 \times 120 \text{ Acm}^{-2} \text{K}^{-2}$] $\Rightarrow S=4 \text{ nm}^2$
- strong coupling 0.67, decreasing gate action above 300 mV due to barriers

Resonant Tunneling Spectroscopy: States below the bandedge



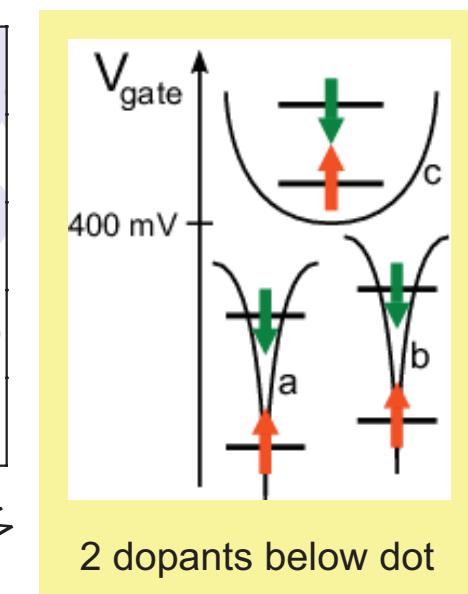
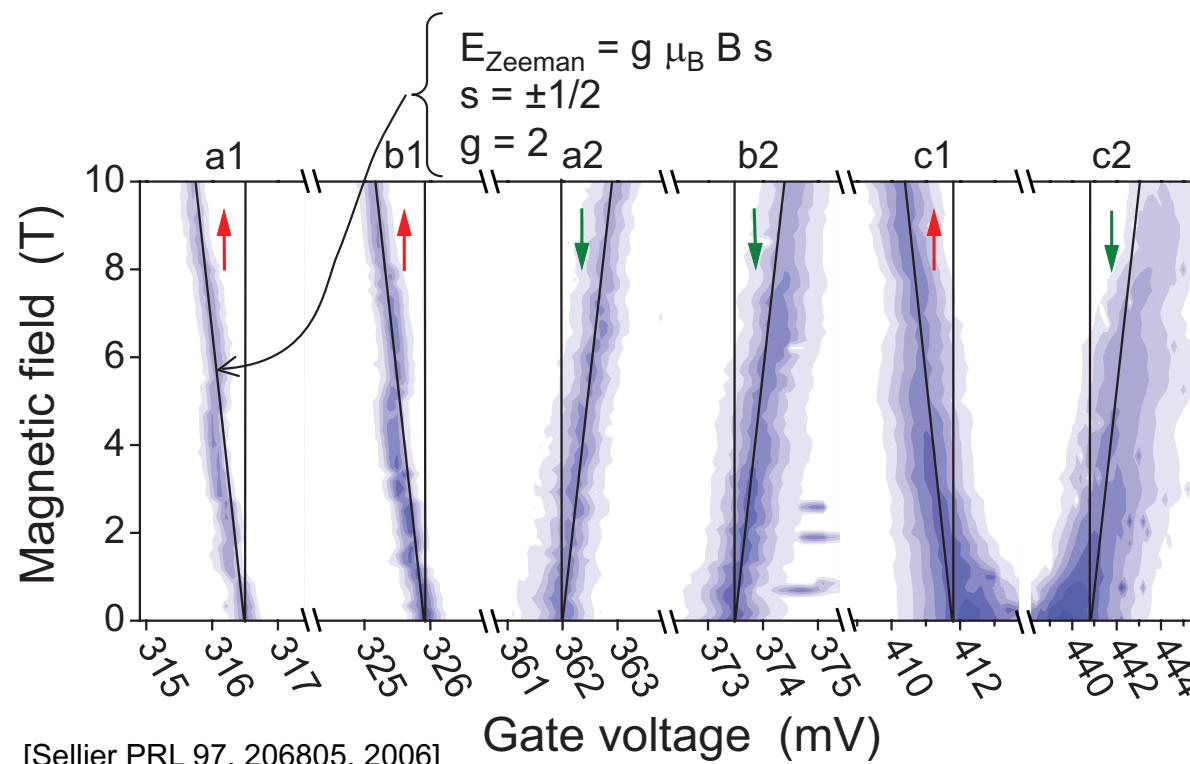
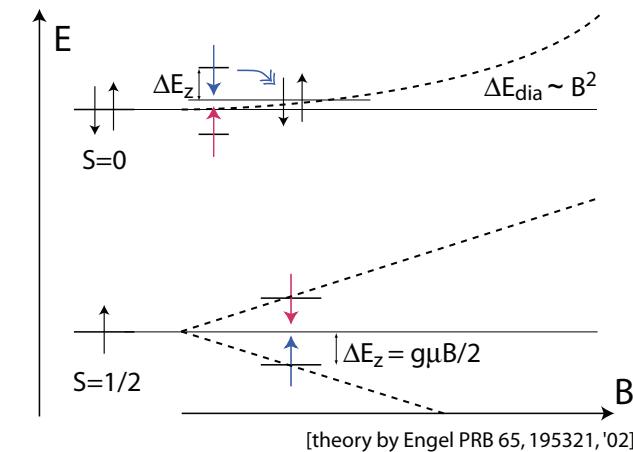
1 in 7 samples shows two peaks below the bandedge with lower conductance and larger peak separation

Stability diagram: the addition-spectrum

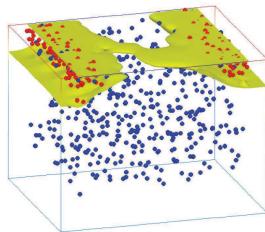


Magnetic Odd / Even effects in transport spectroscopy

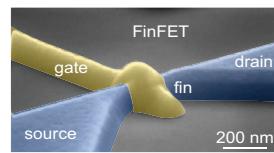
- first $e^- \rightarrow$ Zeeman shift down
- second $e^- \rightarrow$ Zeeman shift up
- singlet \rightarrow spin selective formation!
- Zeeman shift with $g=2$
- independent of direction
→ no orbital effect \Rightarrow dopant



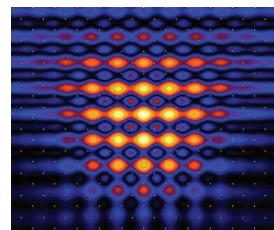
Outline



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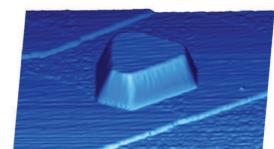
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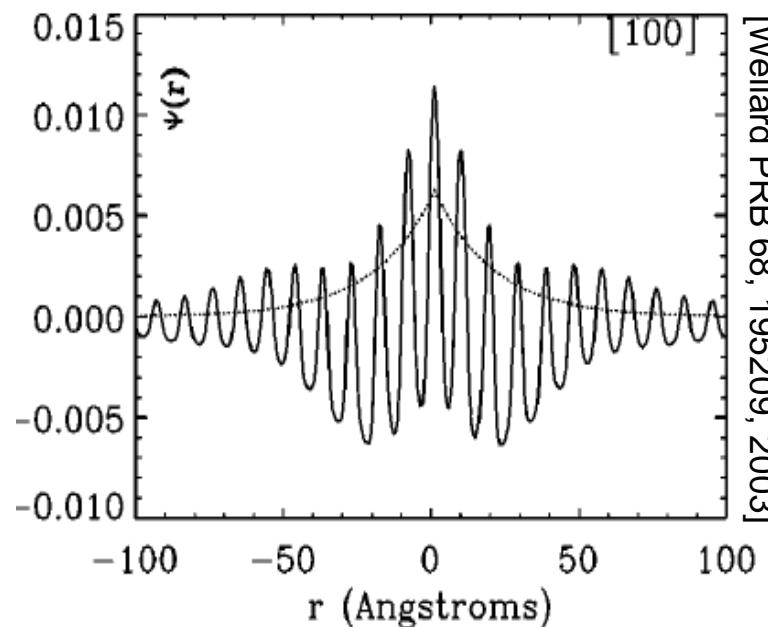
Σ

- Summary



- Other projects

Atomic physics in the solid state



| Level | P | As |
|---------------------|------|------|
| 1s(A ₁) | 45.6 | 53.8 |
| 1s(T ₂) | 33.9 | 32.7 |
| 1s(E) | 32.6 | 31.3 |
| 2p ₀ | 11.5 | 11.5 |
| 2p ₊₋ | 6.4 | 6.4 |
| 3p ₀ | 5.5 | 5.5 |
| 3d ₀ | 3.8 | 3.8 |

[Ramdas Rep. Prog. Phys. 44, 1981]

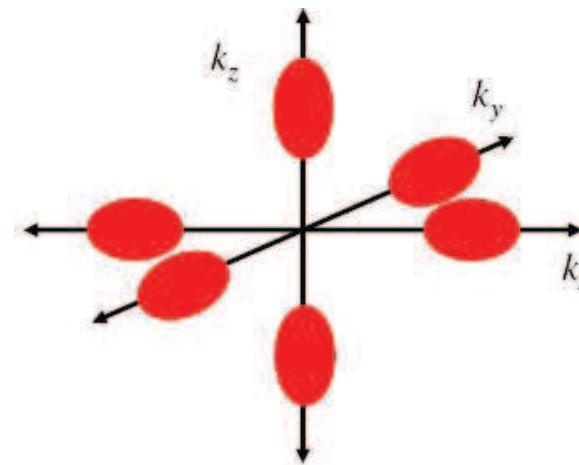
Kohn & Luttinger donor wavefunction in Si

$$\psi(\mathbf{r}) = \int F(\mathbf{k}) \phi_{\mathbf{k}}(\mathbf{r}) d\mathbf{k} \quad [H_0 + U(\mathbf{r})] \psi(\mathbf{r}) = E \psi(\mathbf{r})$$

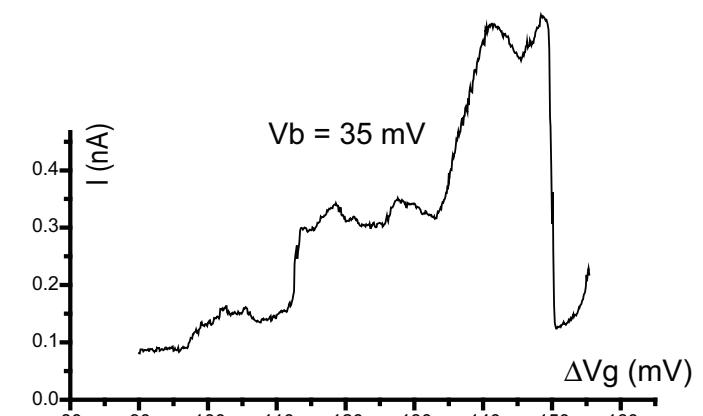
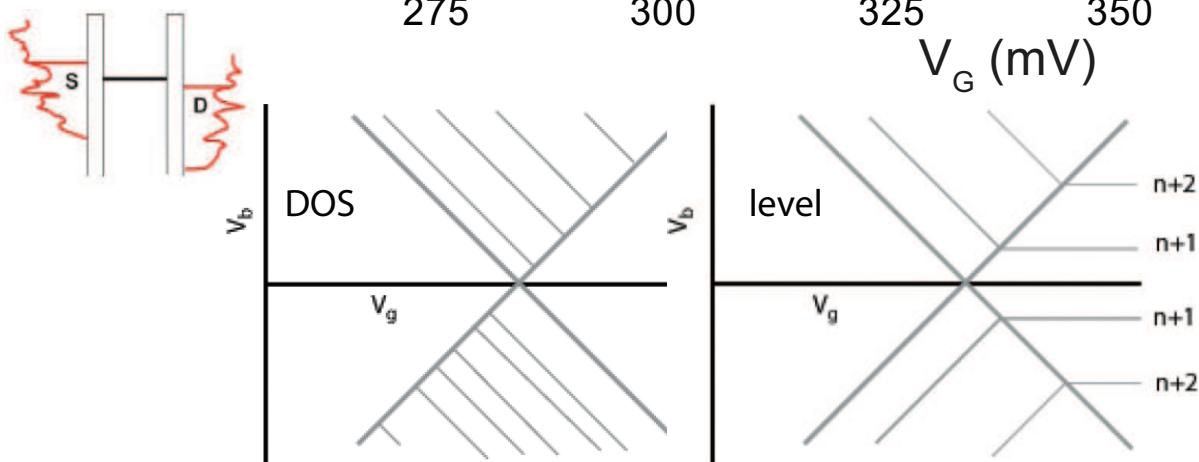
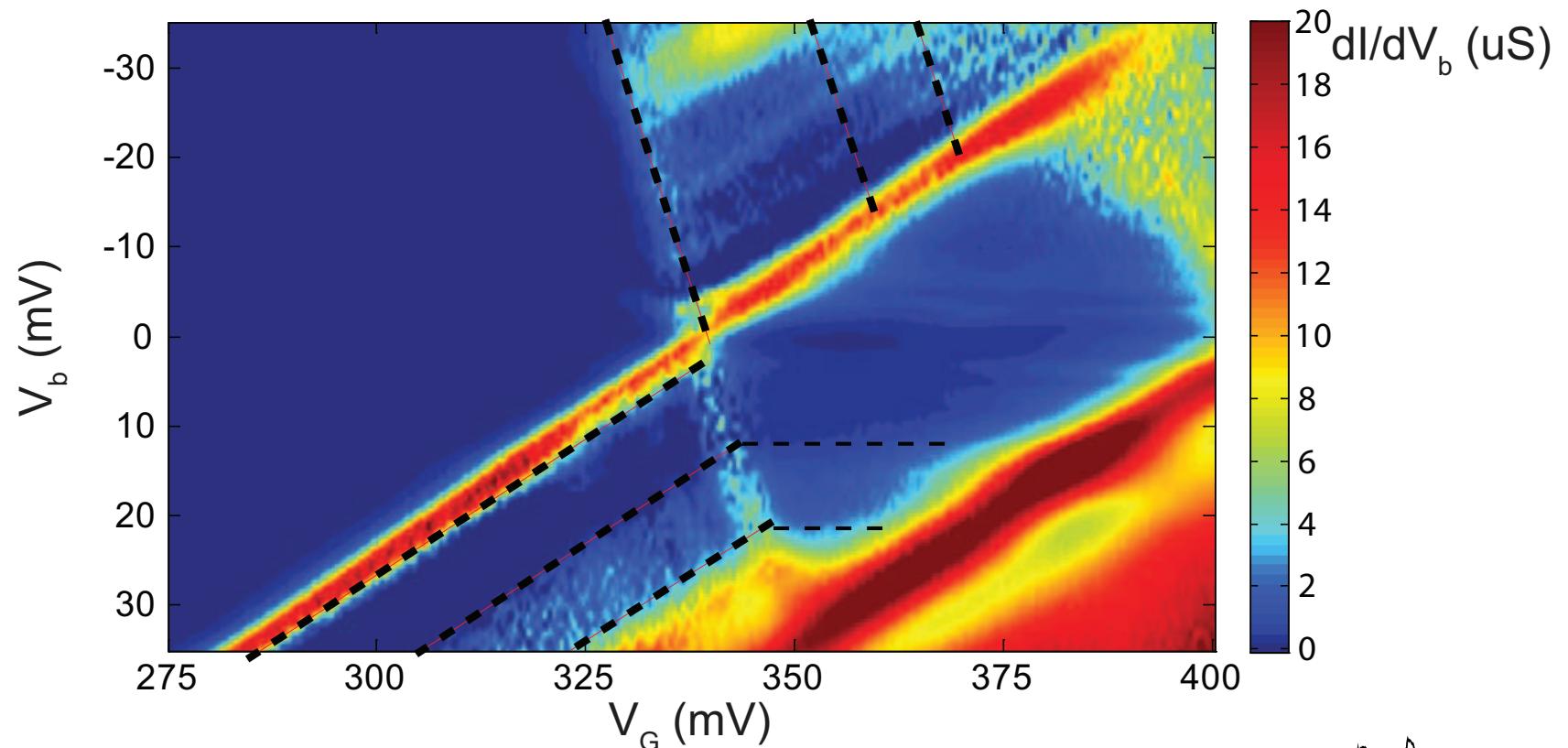
in basis of Si Bloch functions

Properties of the envelop function:

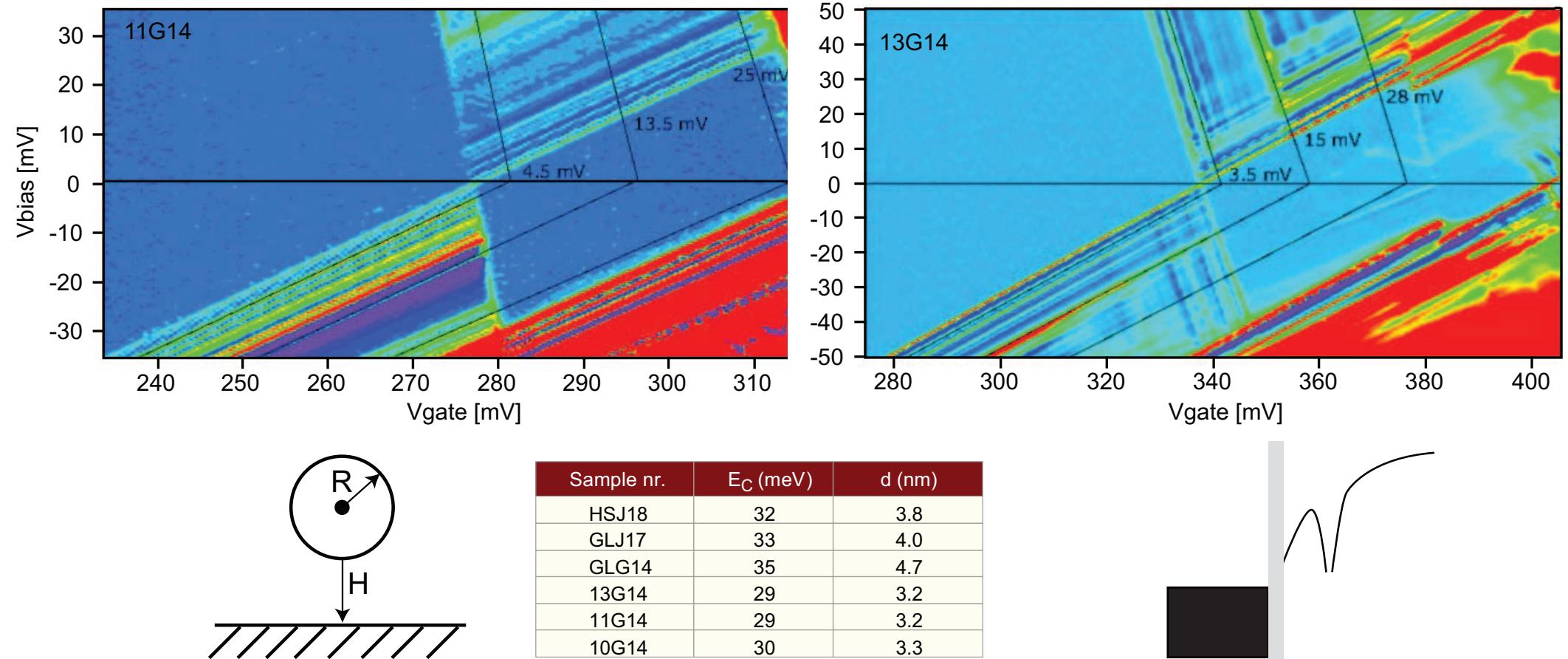
- non-degenerate ground state of A₁ symmetry
- excited triplet of symmetry T₂
- next, excited doublet of symmetry E



Assignment of the level spectrum



The environment of the dopant

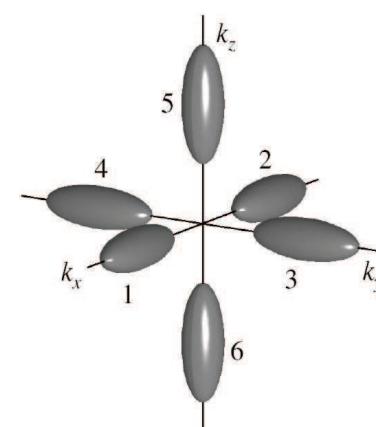


- *excited states spectrum* and *charging energy* differ from device to device
- use charging energy to determine dopant position based on capacitance
- dopant close to interface → region of strong band bending

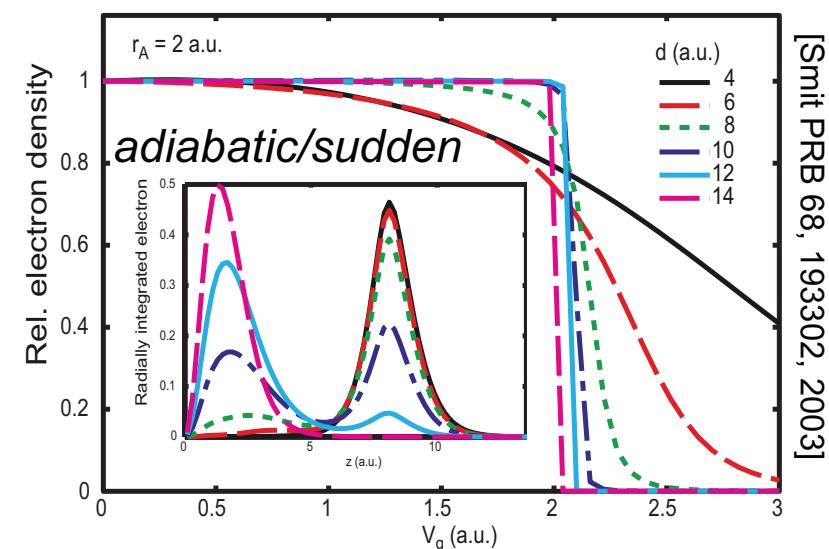
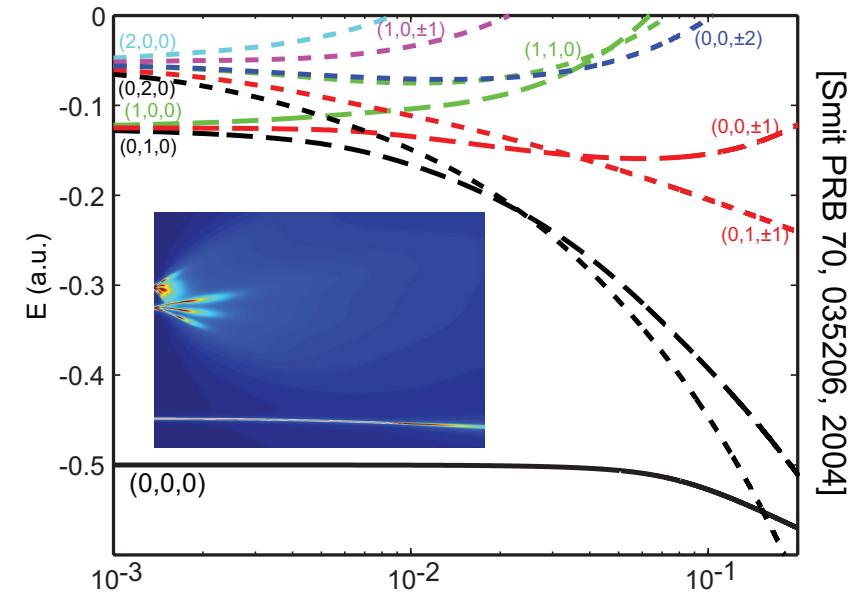
Effect of the electric field: Stark shift

[Ramdas Rep. Prog. Phys. 44, 1981]

| Level | P | As |
|------------------|------|------|
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| 3p ₀ | 5.5 | 5.5 |
| 3d ₀ | 3.8 | 3.8 |



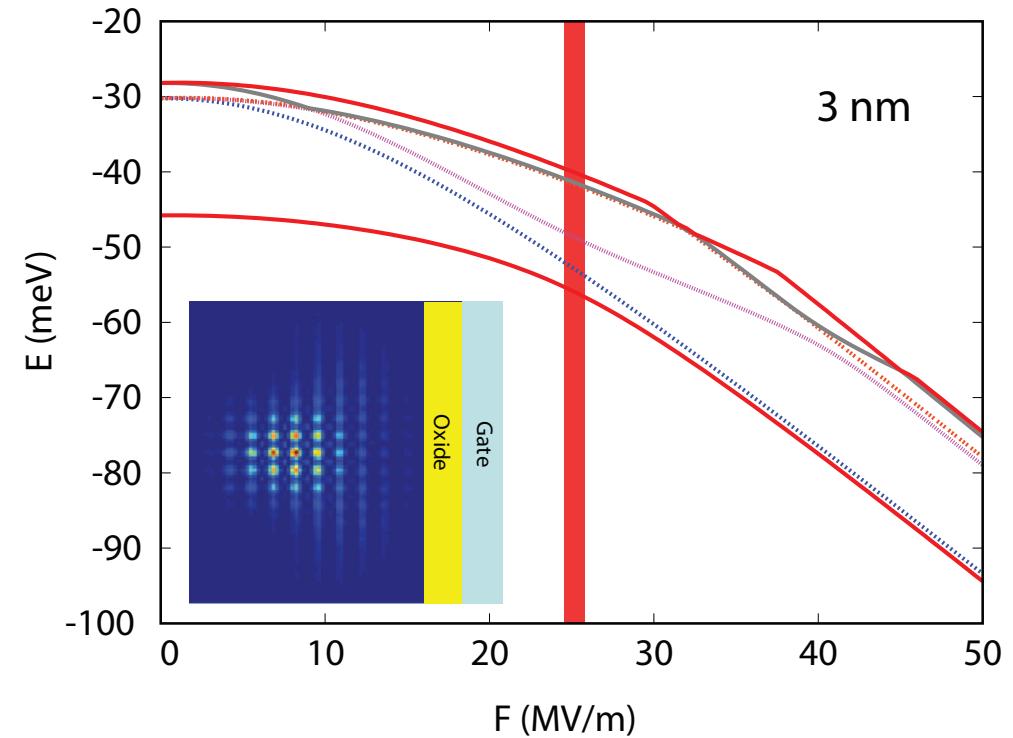
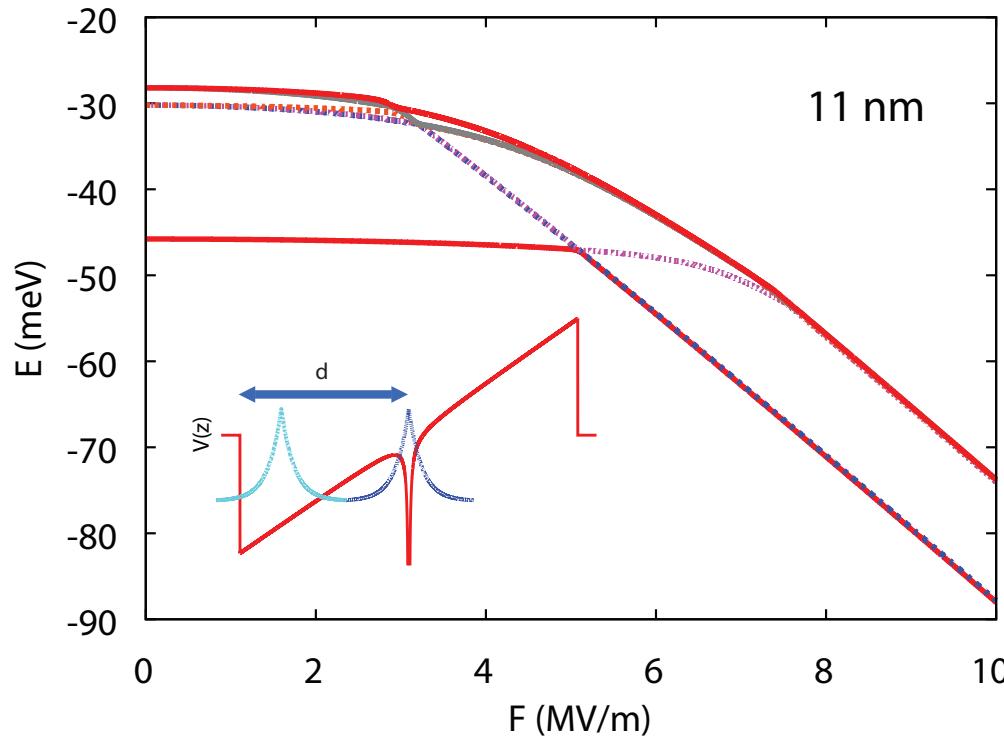
non-degenerate ground state, excited triplet, excited doublet



Calculation of donor/well system for P:Si

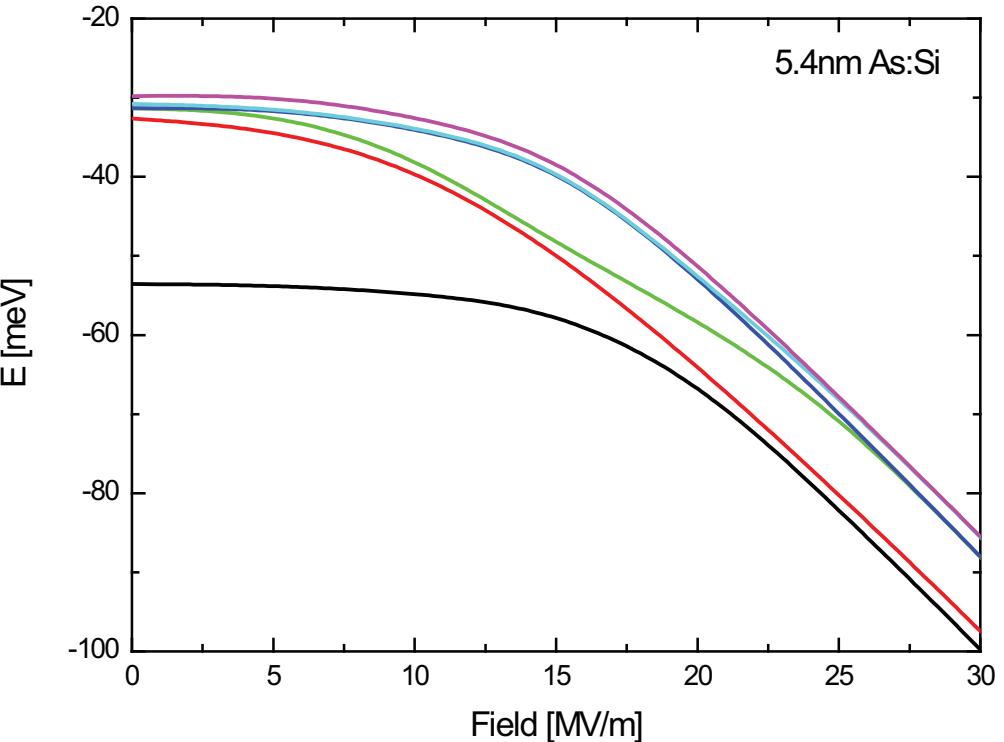
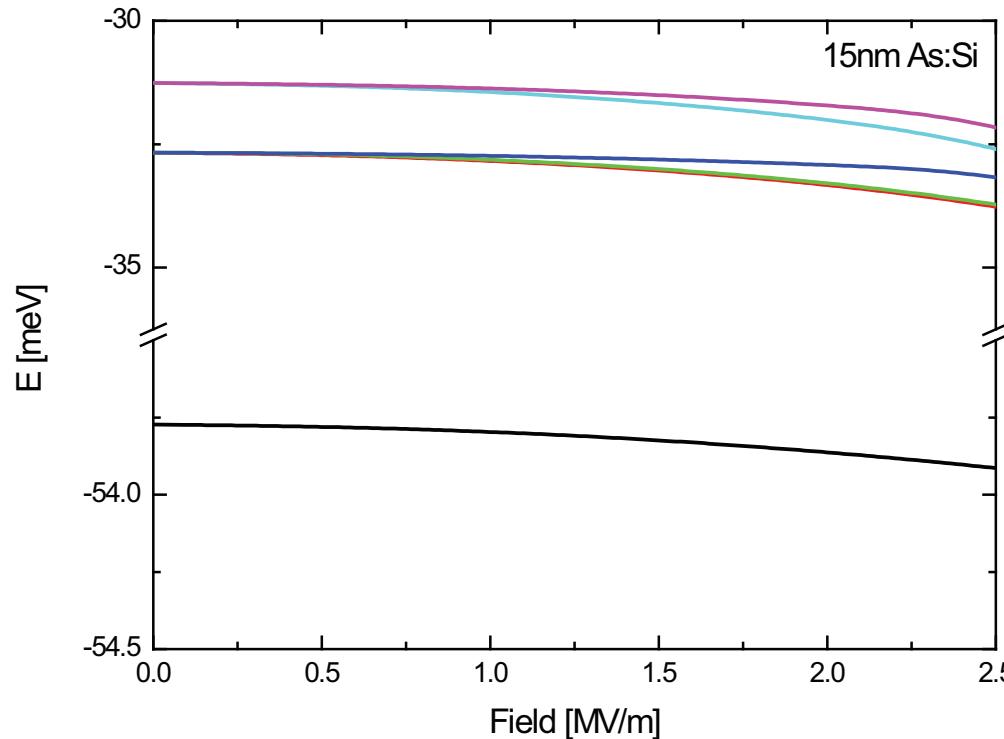
numerical diagonalization of the Hamiltonian in a band minima basis by our collaborators

Cam Wellard & Lloyd Hollenberg, Melbourne University



- below 5 nm donor/interface distance hybridization leads to avoided crossings
- hybrid wavefunction has a strong contribution of the dopant

NEMO for our situation: Arsenic donor 3-6 nm from the interface

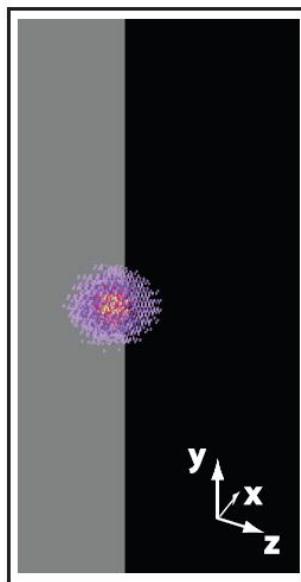


- perfect agreement of the tight binding calculation with bulk measurements
- a dopant close to interface leads to an anti-crossing region

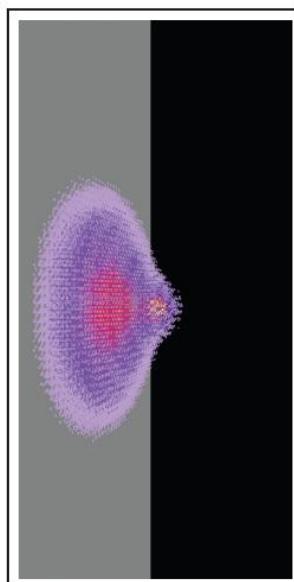
[NEMO work by Rajib Rahman in Gerhard Klimeck's group at Purdue together with Hollenberg]

Hybridization with well state leads to a molecular system

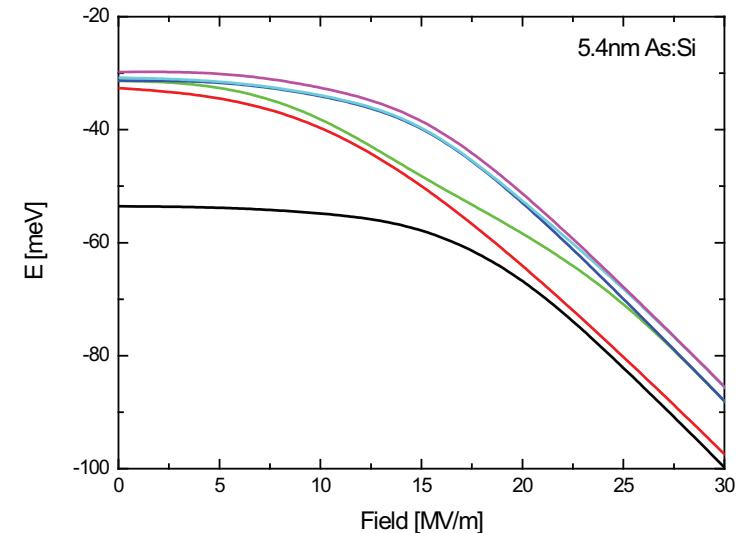
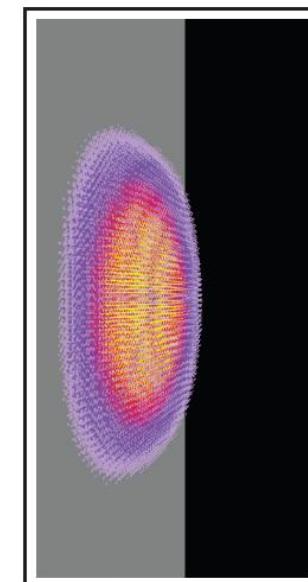
$F=0 \text{ MV/m}$



$F=20 \text{ MV/m}$

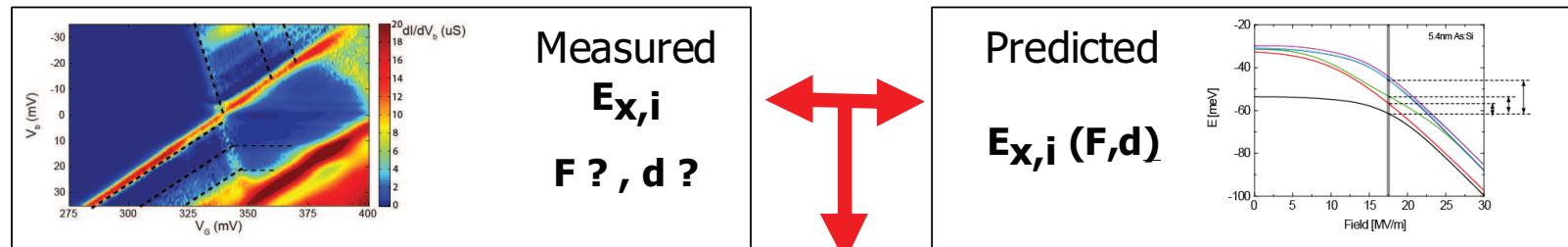


$F=40 \text{ MV/m}$



co.: Rajib Rahman & Gerhard Klimeck (Purdue) and Cam Wellard & Lloyd Hollenberg (Melbourne Uni.)

Fit excited states of the dopants to model

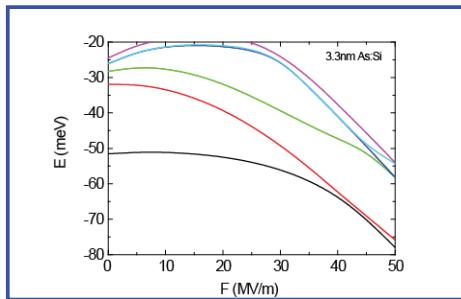


| Sample | 10G16 | 11G14 | 13G14 | HSJ18 | GLG14 | GLJ17 |
|--------------------|-------|-------|-------|-------|-------|-------|
| Measured Ex1 (meV) | 2 | 4,5 | 3,5 | 5 | 1,3 | 2 |
| Measured Ex2 (meV) | 15 | 13,5 | 15,5 | 10 | 10 | 7,7 |
| Measured Ex3 (meV) | 23 | 25 | 26,4 | 21,5 | 13,2* | 15 |
| Predicted F (MV/m) | 37,3 | 31,6 | 35,4 | 26,1 | 23,1 | 21,8 |
| Predicted r (nm) | 3,34 | 3,51 | 3,24 | 4,05 | 5,16 | 4,92 |
| Chi-square | 0,59 | 0,04 | 0,17 | 0,63 | 0,28 | 0,96 |
| Ex1 (meV) | 2,2 | 4,5 | 3,6 | 4,9 | 1,8 | 1,1 |
| Ex2 (meV) | 15,6 | 13,5 | 15,7 | 10,2 | 10,0 | 7,7 |
| Ex3 (meV) | 23,0 | 25,0 | 26,3 | 21,4 | 13,2 | 15,3 |

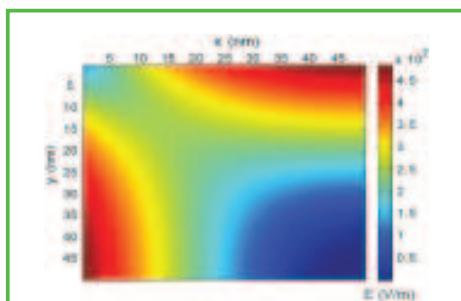
- a 2D (F, d) fit of the first 3 excited states of the model works well for the 6 samples
- $S_{\text{total}}(\text{As})=0.53 \text{ meV}$ equal to the measurement error
- $S_{\text{total}}(\text{P})=1.5 \text{ meV}$ leading to a 0.99 certainty for the As model

Comparison between data and model in a broader context

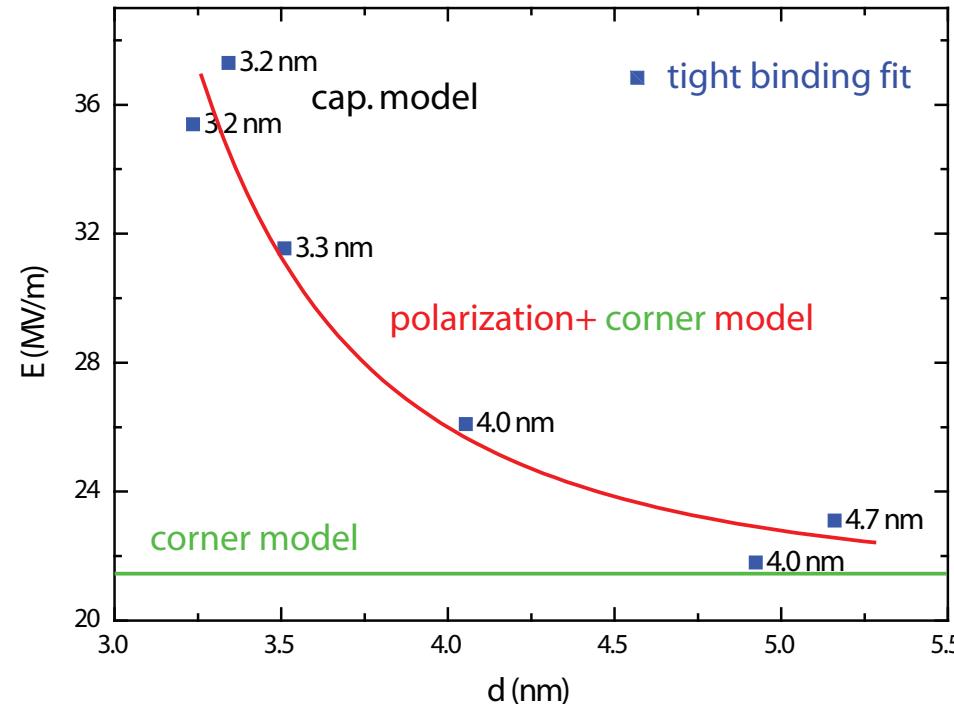
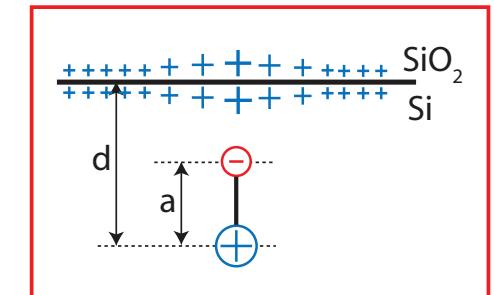
Tight binding



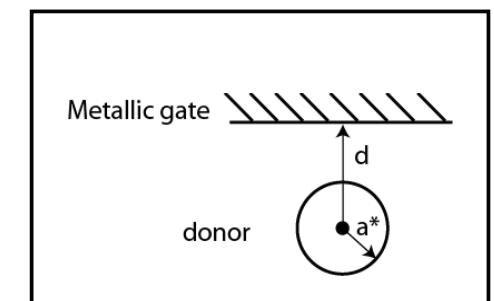
Corner effect



Polarization



Capacitive model

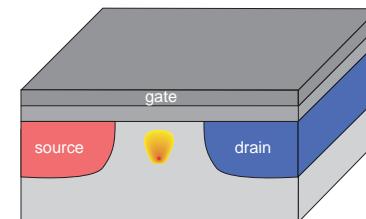


- field at the dopant site is higher than expected from the corner model
- magnitude and functional form of polarization layer + corner field fit well
- independent capacitive data in decent agreement with tight-binding fit

[paper in preparation by Delft, Melbourne, Purdue groups]

Summary

- Transport through a triple-gate nano-MOSFET
 - corner effect → 1D channel with 4 nm^2 cross section
- Access to a single dopant
 - ionization energy of 1st e^- consistent with As in Si
 - charging energy for 2nd e^- lowered due to electrodes
- Atomic physics in a MOSFET
 - large E-field → strong Stark effect → new level spectrum
 - hybrid wavefunction of dopant and interface well, anti-crossing



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